

Canadian Light Source

XRD Summer School

August 16 – 18, 2022

Thin Film Characterization with X-Rays

beatriz.moreno@lightsource.ca



TOPICS

1. Motivation

2. Is the film thin?

3. X-ray Attenuation

Techniques:

a) GI-powder XRD

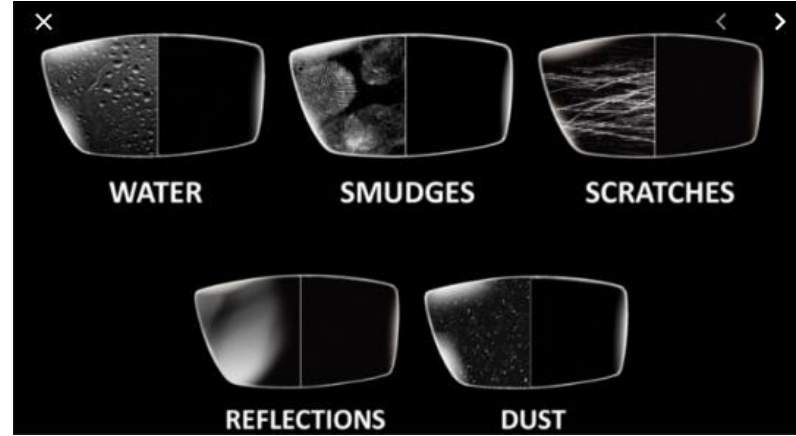
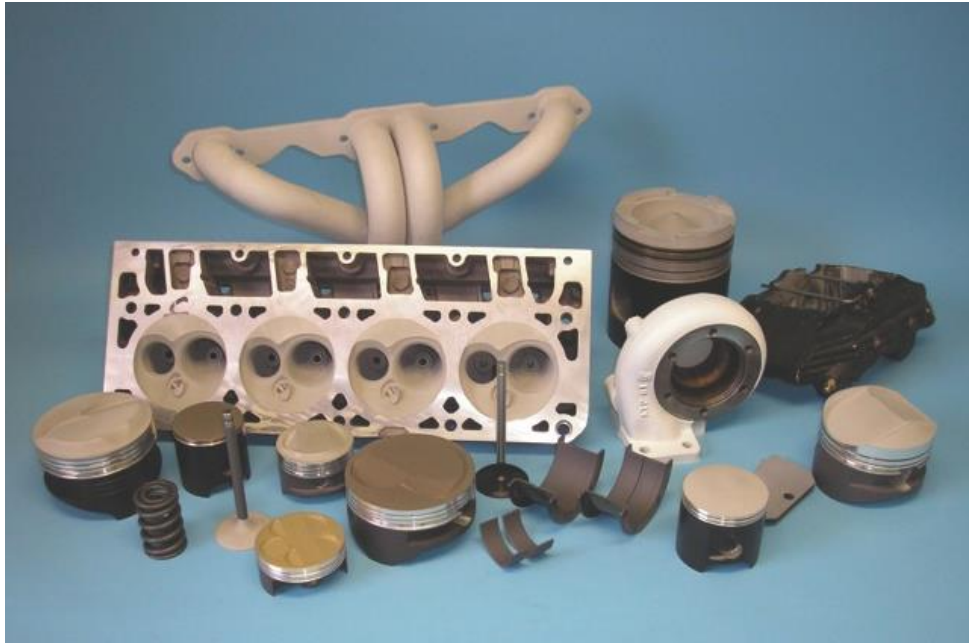
b) GI-single crystal XRD

c) Reflectivity

d) GISAXS



Motivation

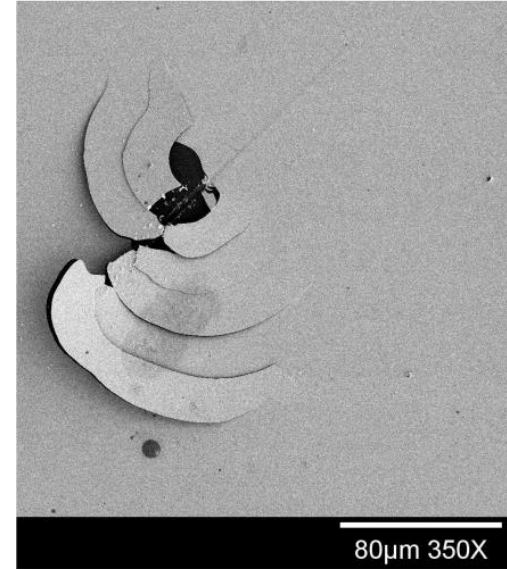
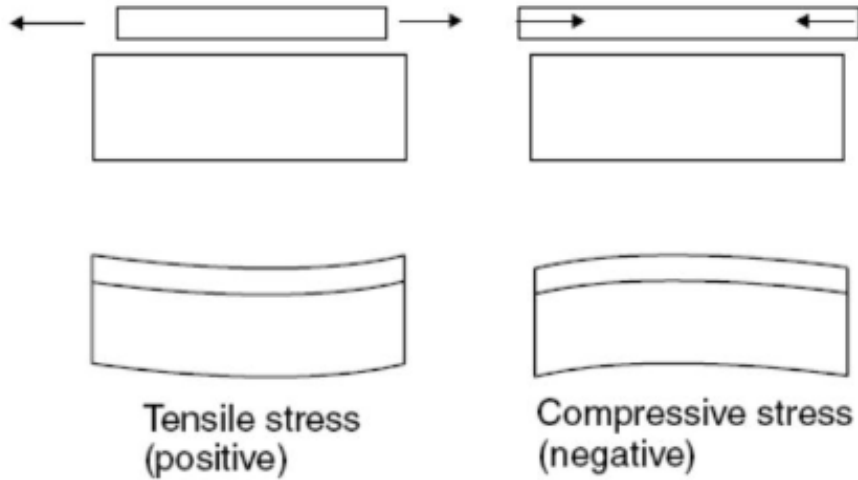


Three Most Common Issues Coatings Address:

- 1. Friction**
- 2. Heat**
- 3. Corrosion**



Structure Performance



Stress fracture patterns in ALD W/Si



What can we measure?

Small angle x-ray reflectivity

GI-SAXS

GI-WAXS -- GI -- PXRD
-- GI -- RSM

Reflectivity

XRD

Pole figures

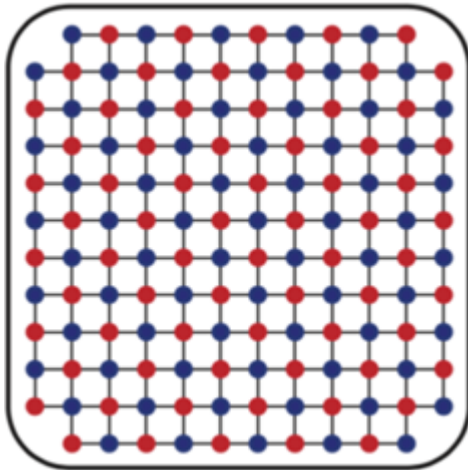
They yield information about:

- ✓ Film thickness, roughness, porosity
- ✓ Structure, stress, texture, defects
- ✓ Composition, interdiffusion, gradients
- ✓ Buried nanostructures, size, shape, ordering

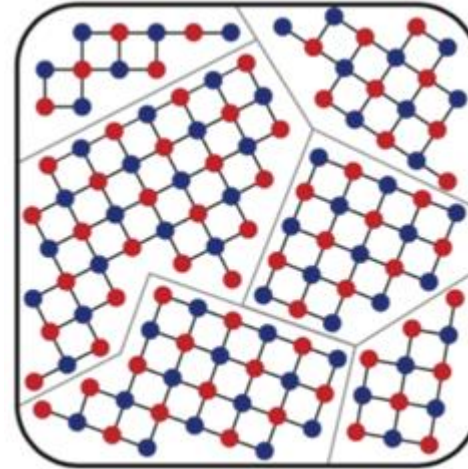


What kind of films can we measure?

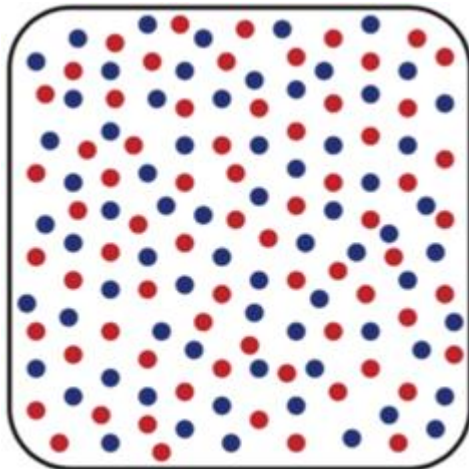
Single-crystal



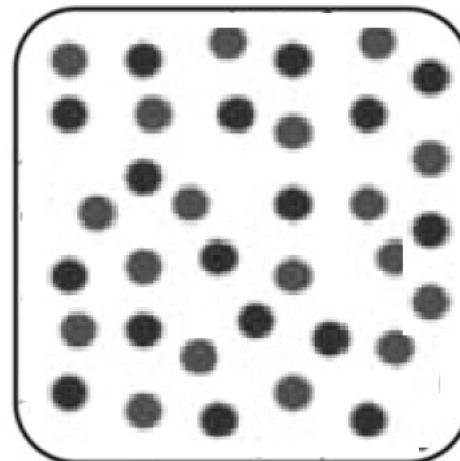
Poly-crystalline



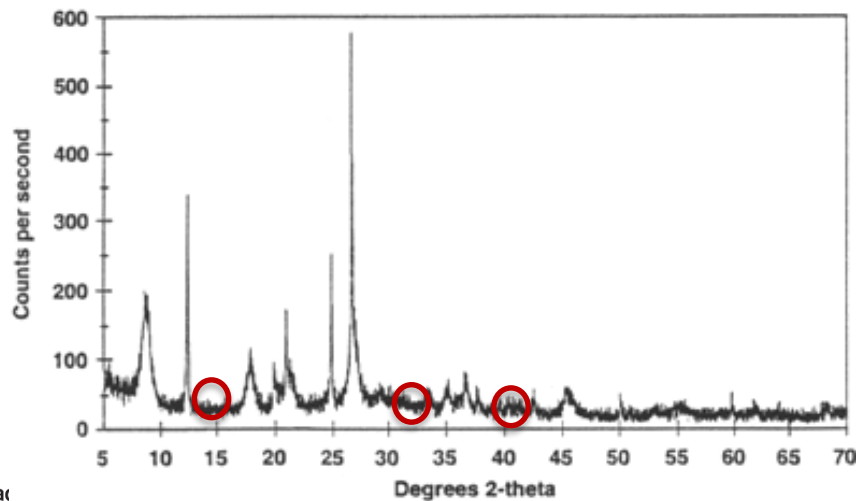
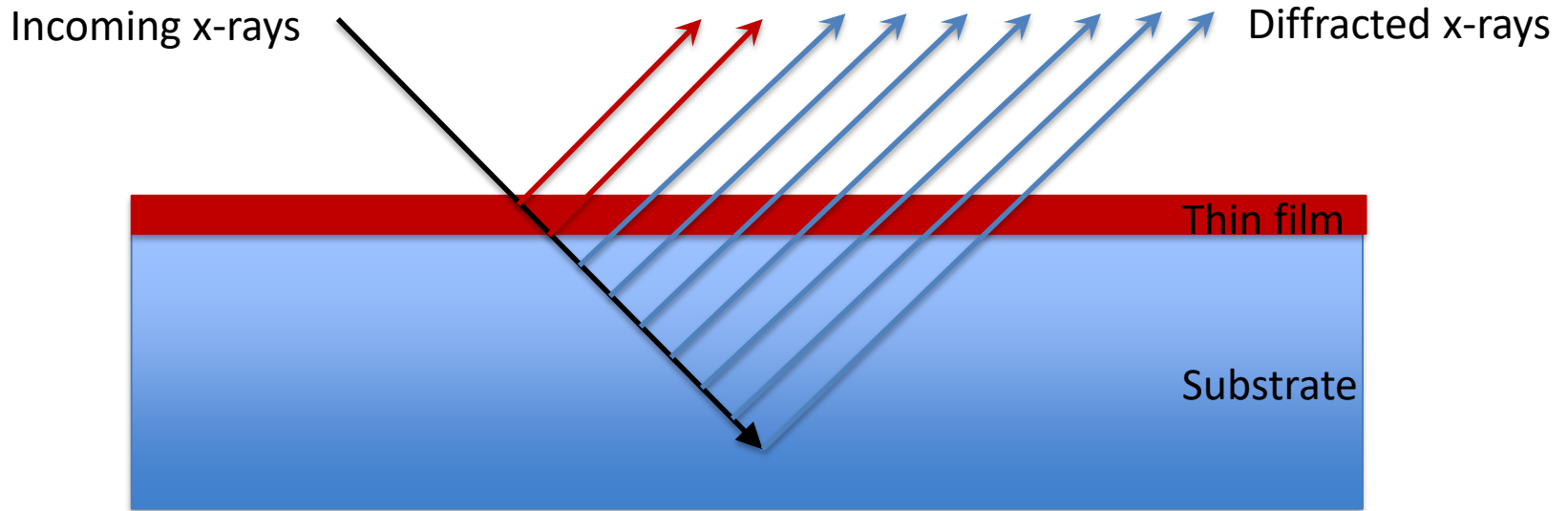
Amorphous



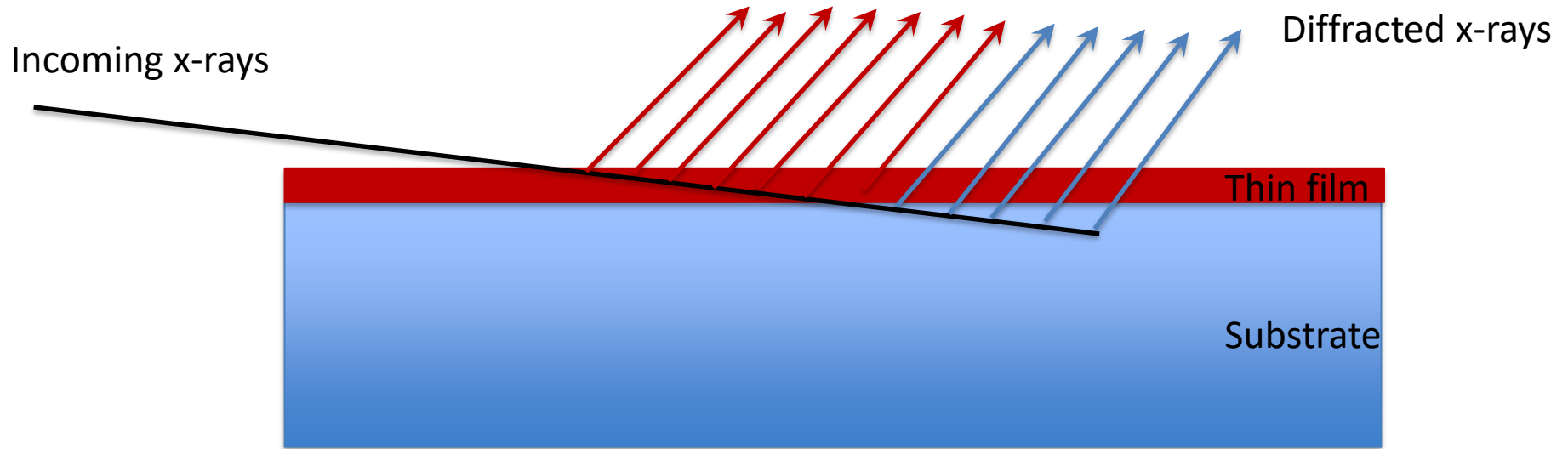
Nanostructures



Using X-Rays to investigate thin films



The grazing incidence geometry enhances the film signal relative to the substrate signal



X-Rays attenuation length

The **attenuation length** ε is the distance over which the x-ray beam intensity has dropped to $1/e$ of its incident intensity.

$$e = 2.718281828459045$$
$$1/e = 0.367879441171$$

Denser materials will have shorter attenuation lengths.

Higher energies will have longer attenuation lengths

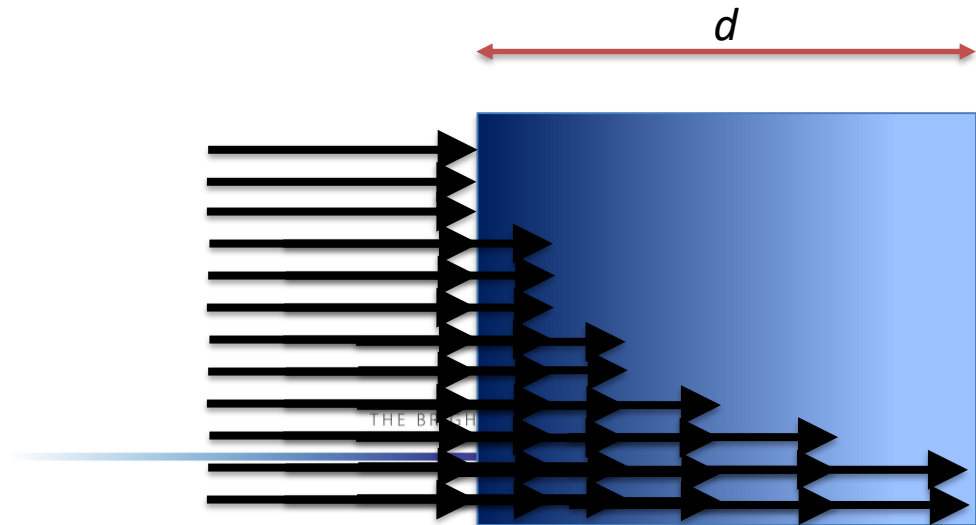
$$I = I_0 e^{-\frac{d}{\varepsilon}}$$

The **attenuation coefficient** μ is simply the inverse of the attenuation length

$$I = I_0 e^{-\mu \cdot d}$$

Where to find attenuation lengths of materials:

- CXRO
- XOP/XPOWER
- ...





X-Ray Database

Nanomagnetism

X-Ray Microscopy

EUV Lithography

EUV Mask Imaging

Reflectometry

Zoneplate Lenses

Coherent Optics

Nanofabrication

Optical Coatings

Engineering

Education

Publications

Contact



The Center for X-Ray Optics is a multi-disciplined research group within Lawrence Berkeley National Laboratory's (LBNL) Materials Sciences Division (MSD). [Notice to users.](#)

X-Ray attenuation length

X-Ray Interactions With Matter

Introduction

Access the [atomic scattering factor](#) files.

Look up [x-ray properties of the elements](#).

The [index of refraction](#) for a compound material.

The x-ray [attenuation length](#) of a solid.

X-ray transmission

- Of a [solid](#).
- Of a [gas](#).

X-ray reflectivity

- Of a [thick mirror](#).
- Of a [single layer](#).
- Of a [bilayer](#).
- Of a [multilayer](#).

The diffraction efficiency of a [transmission grating](#).

Related calculations:

- Synchrotron [bend magnet radiation](#).

[Other x-ray web resources.](#)

[X-ray Data Booklet](#)

X-Ray attenuation length

X-Ray Attenuation Length

- Choose from a list of common materials: ▾
- Chemical Formula:
- Density: gm/cm³ (enter negative value to use tabulated values.)
- Scan ▾ from to in steps (< 500).
(NOTE: Energies must be in the range 30 eV < E < 30,000 eV, Wavelength between 0.041 nm < Wavelength < 41 nm)
- At fixed =

To request a ▾ ▾ press this button:

To reset to default values, press this button:



X-Ray attenuation length

X-Ray Attenuation

- Choose from a list of common materials:
- Chemical Formula:
- Density: gm/cm³ (enter negative)
- Scan from
(NOTE: Energies must be in the range 30 eV to 100,000 eV)
- At fixed =

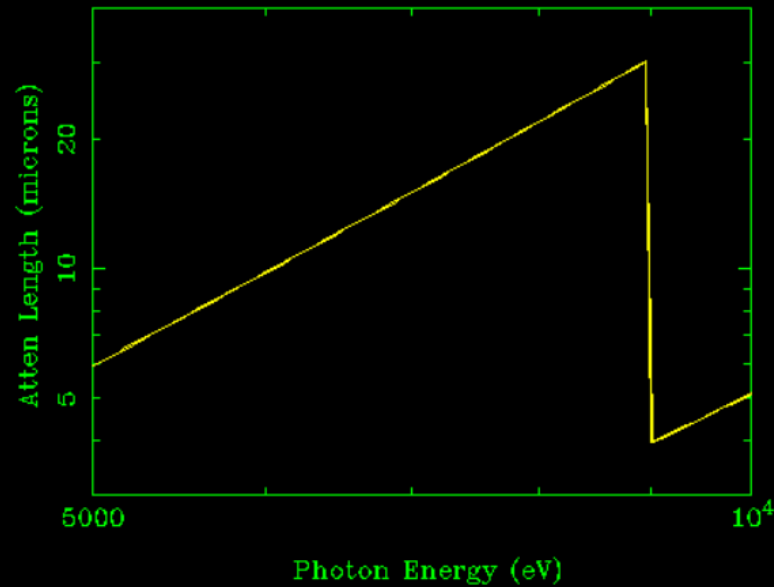
To request a press this button:

To reset to default values, press this button:

X-Ray Attenuation Length: [data file here](#)

Print

Cu Density=8.96, Angle=90.deg



length < 41





X-Ray Database



Zone Plate Education



X-Ray attenuation length

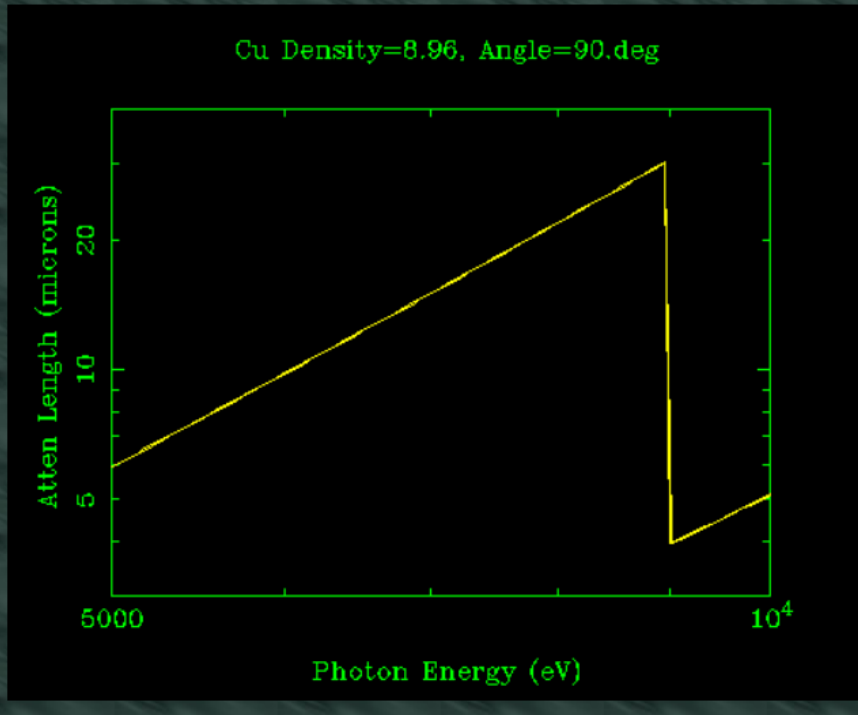
X-Ray Attenuation Length: [data file here](#)

Print

X-Ray Attenuation

Cu Density=8.96, Angle=90.deg
Photon Energy (eV), Atten Length (microns)

5000.00	5.96392
5034.78	6.07762
5069.80	6.19352
5105.06	6.31168
5140.57	6.43210
5176.32	6.55489
5212.33	6.68003
5248.58	6.80778
5285.09	6.93802
5321.85	7.07069
5358.87	7.20583
5396.14	7.34361
5433.67	7.48427
5471.47	7.62763
5509.53	7.77389
5547.85	7.92298
5586.44	8.07487
5625.29	8.22963
5664.42	8.38748
5703.82	8.54873
5743.49	8.71308
5783.44	8.88042
5823.67	9.05096
5864.17	9.22514



length < 41

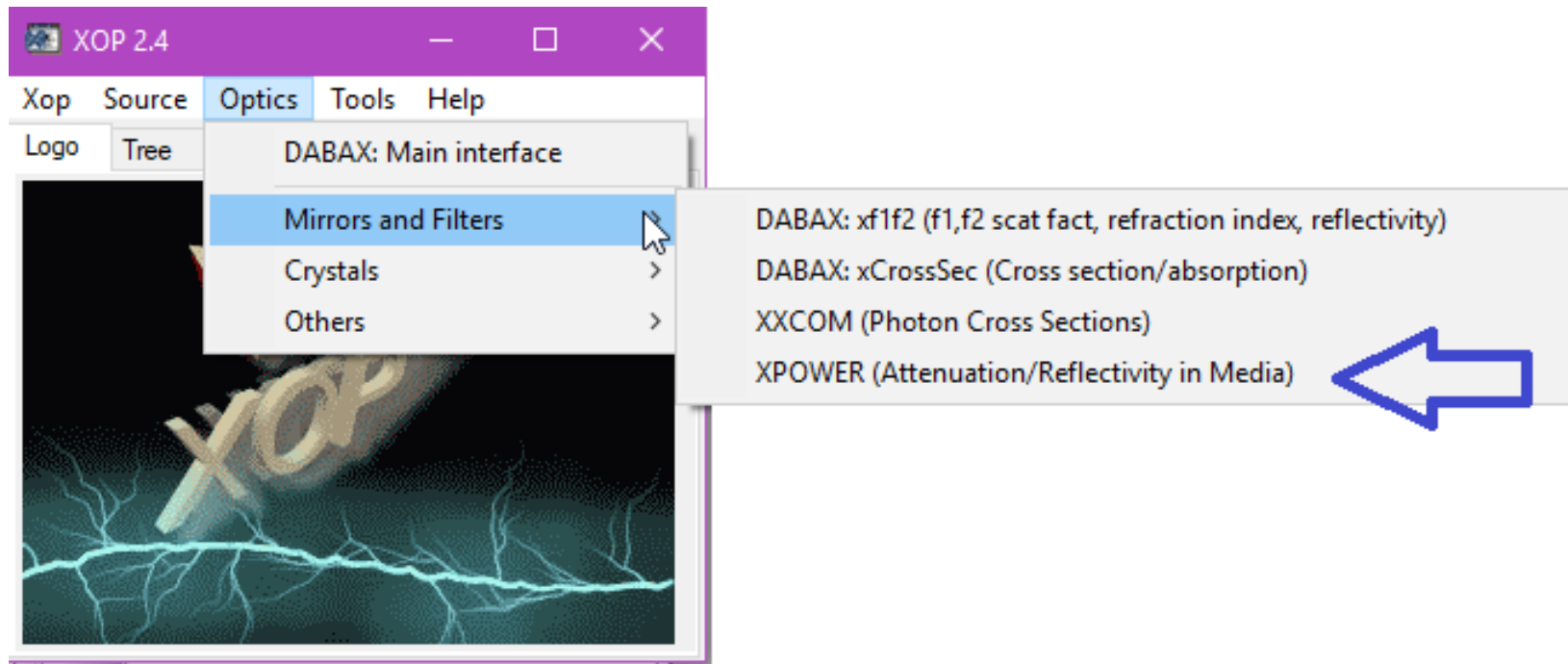
Element 29: Cu

Edge	keV
K	8.9789

X-Ray attenuation length

XOP/XPOWER

<https://www.aps.anl.gov/Science/Scientific-Software/XOP>



X-Ray attenuation length

The image displays the Xpower software interface, which is used for calculating X-ray attenuation and reflectivity. The main window, titled "Xpower input data", contains several input fields for configuring the simulation. The "f1f2 dataset" is set to "f1f2_Windt.dat", the "Mu dataset" is "CrossSec_XCOM.dat", and the "Source" is "Normalized to 1 (E from keyboard)". The energy range is defined by "From energy [eV]: 5000.0000" and "To energy [eV]: 50000.000", with "Energy points: 100". The "Number of elements" is set to "1". The "1st oe formula" is "Cu", the "kind" is "Filter", and the "Filter thick[mm]" is "0.50000000". The "Density [g/cm^3]" is currently "?".

The "Xpower results" window shows a plot titled "Local properties of optical elements". The y-axis is labeled "[oe 1] Mu[cm^-1]" and ranges from 0 to 2500. The x-axis is labeled "Photon Energy [eV]" and ranges from 0 to 5x10^4. The plot shows a sharp peak at approximately 8512.55 eV, with a value of about 2400 cm^-1. The current cursor position is X:8512.55 Y:1607.81.

The "XOP 2.3" window shows a 3D rendering of the XOP logo with a lightning bolt effect.

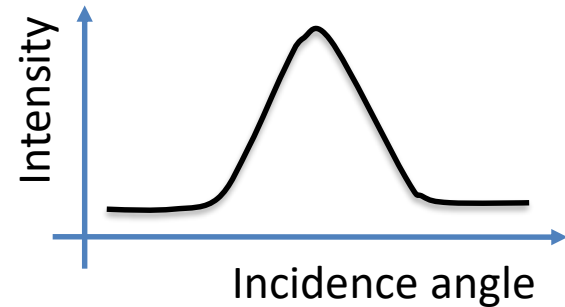
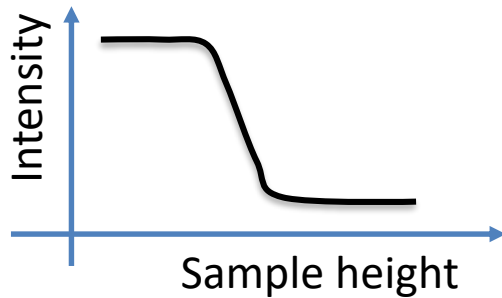
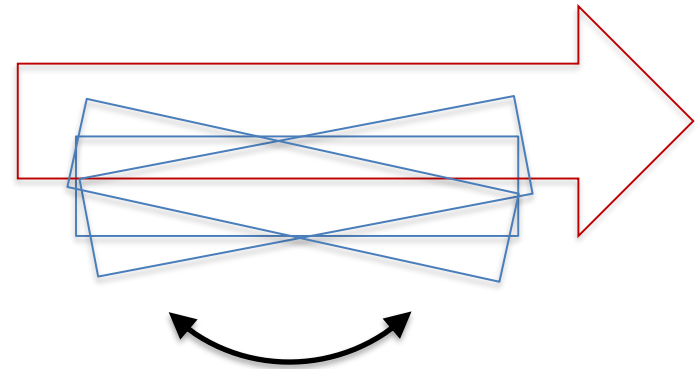
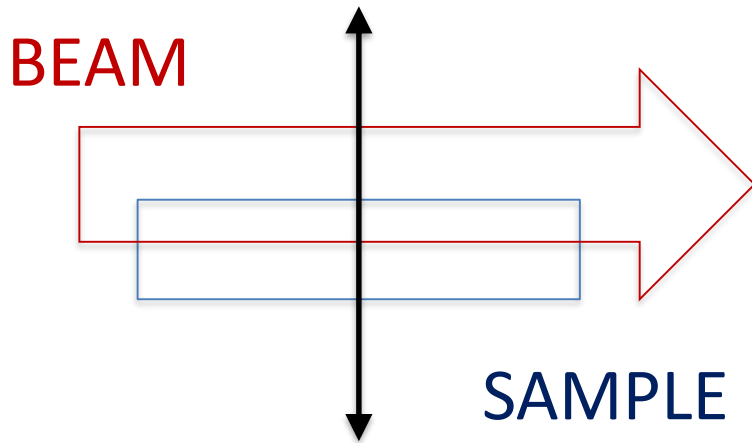
The "Xpower 1.12" window displays the following text:

Xpower
Attenuation & reflectivity in media.
Effect on source spectrum

How do we measure?



Sample alignment



Iterate!



Grazing incidence diffraction

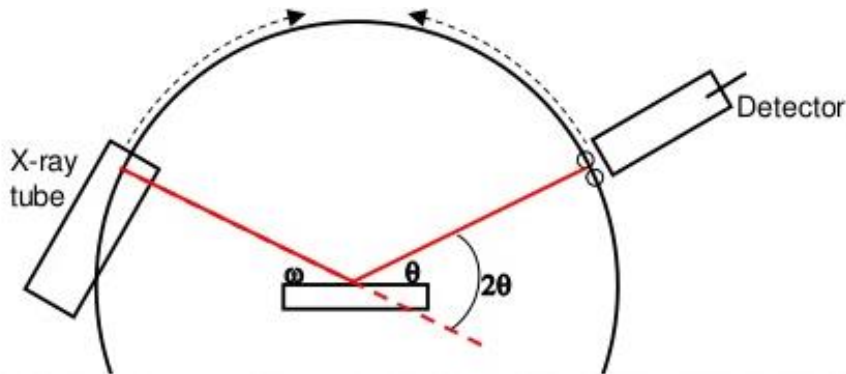
applied to

Polycrystalline films

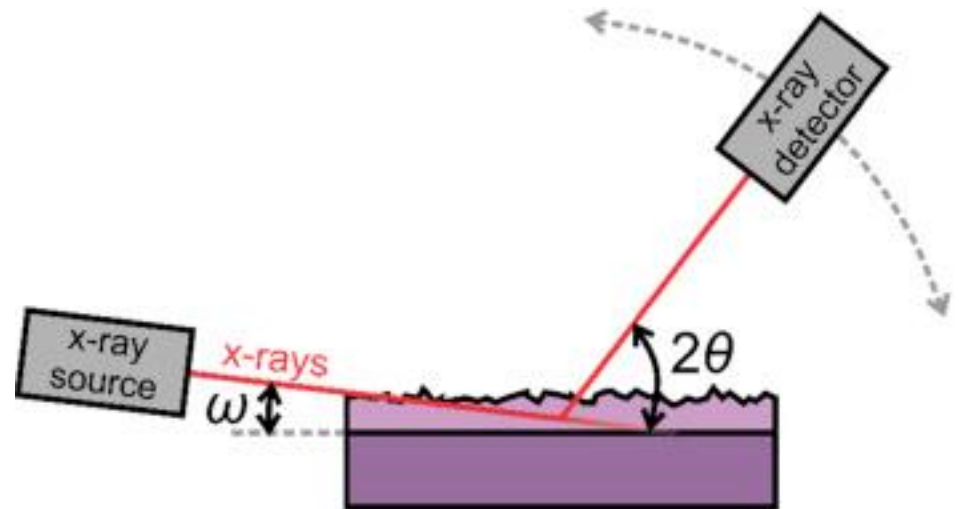


Grazing incidence diffraction

Regular specular geometry, $\omega = \theta$



Grazing incidence geometry

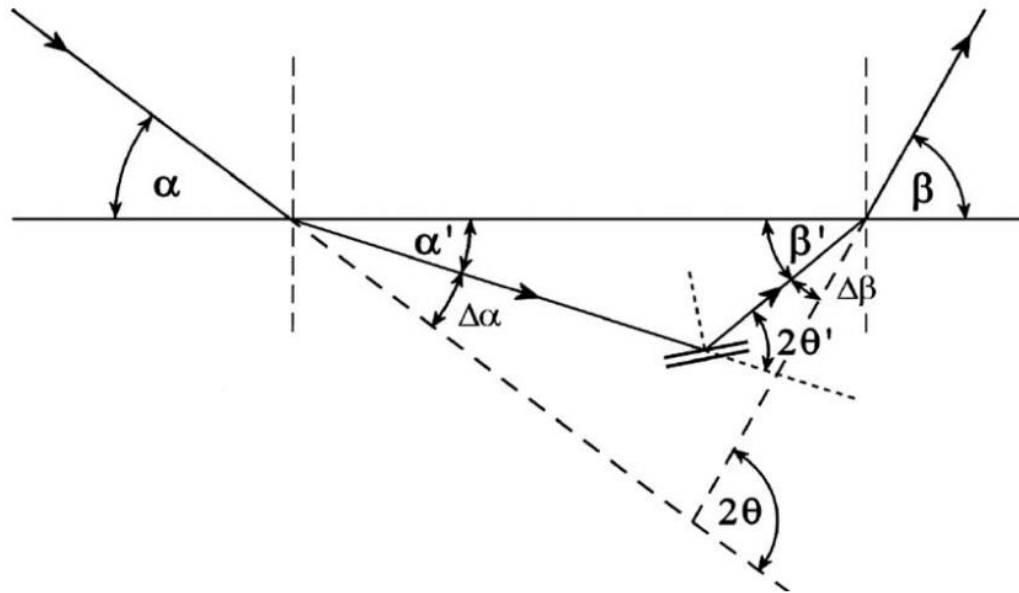


<https://www.sciencedirect.com/science/article/pii/S0022311517313946>



Grazing incidence diffraction

Refraction correction



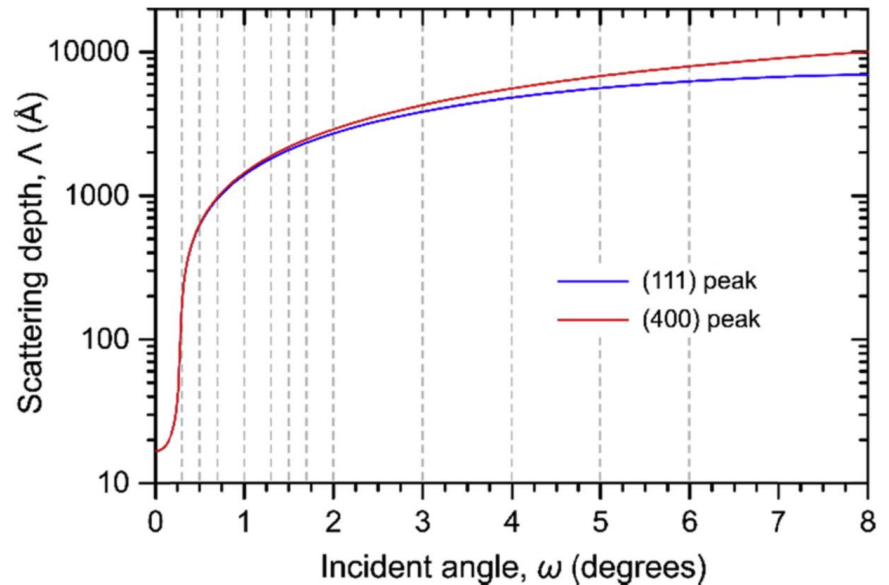
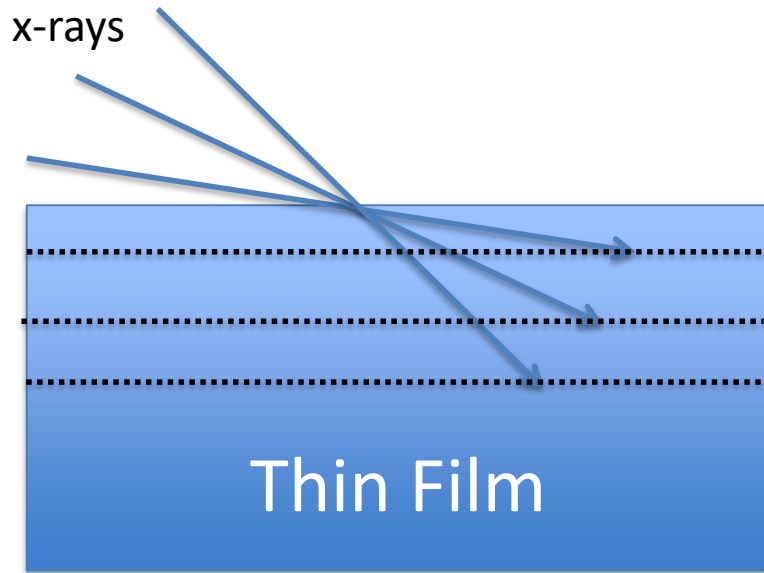
$$\Delta 2\theta = \delta [\cot \alpha + \cot(2\theta - \alpha) + 2 \tan \theta]$$

Powder Diffraction **24**(S1): S11-S15, 2012



Grazing incidence diffraction

Depth sensitivity

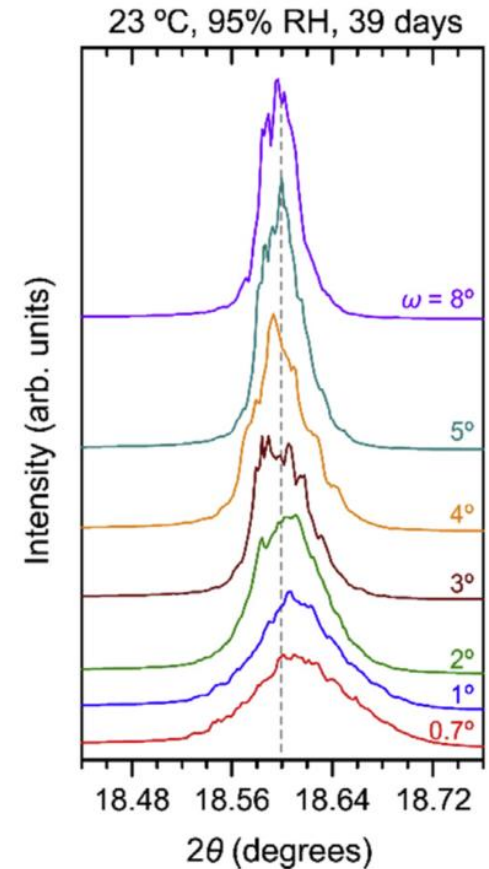
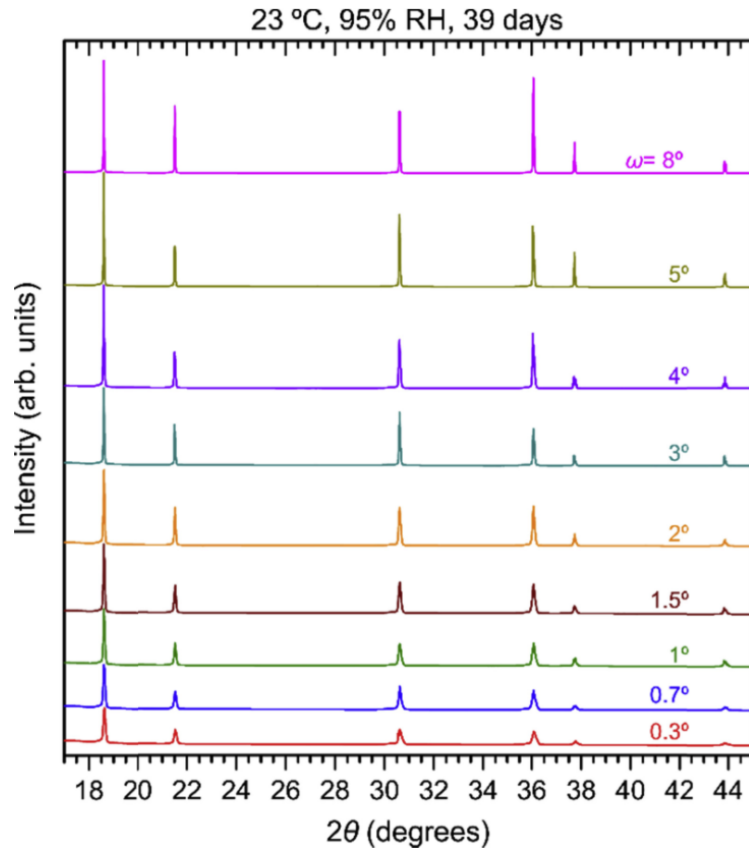


Journal of Nuclear Materials **502**: 68-75, 2018.



Grazing incidence diffraction

Uranium Oxide (UO_2) exposed to air



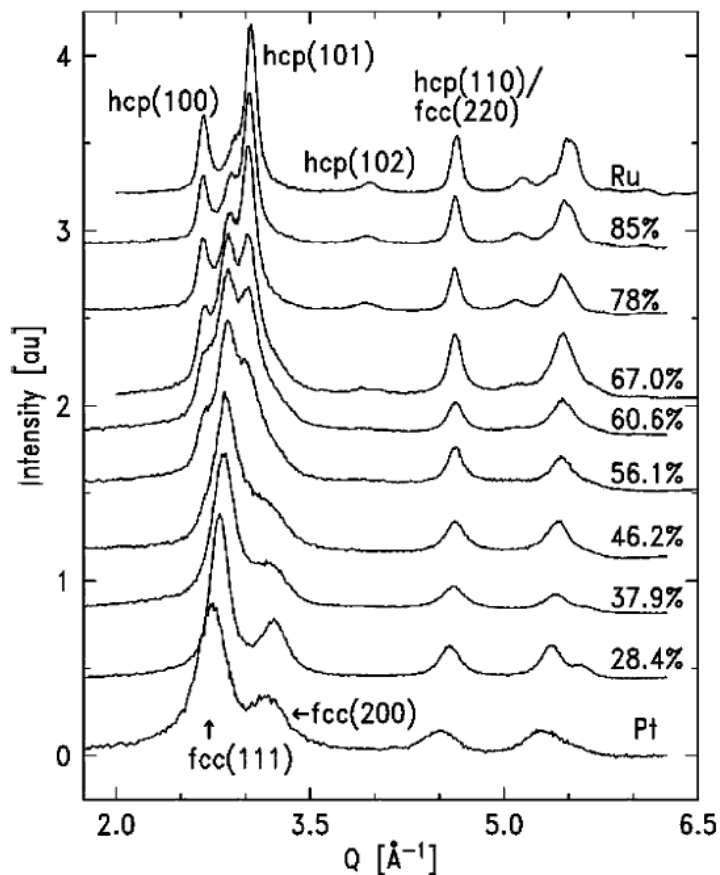
Journal of Nuclear Materials **502**: 68-75, 2018.



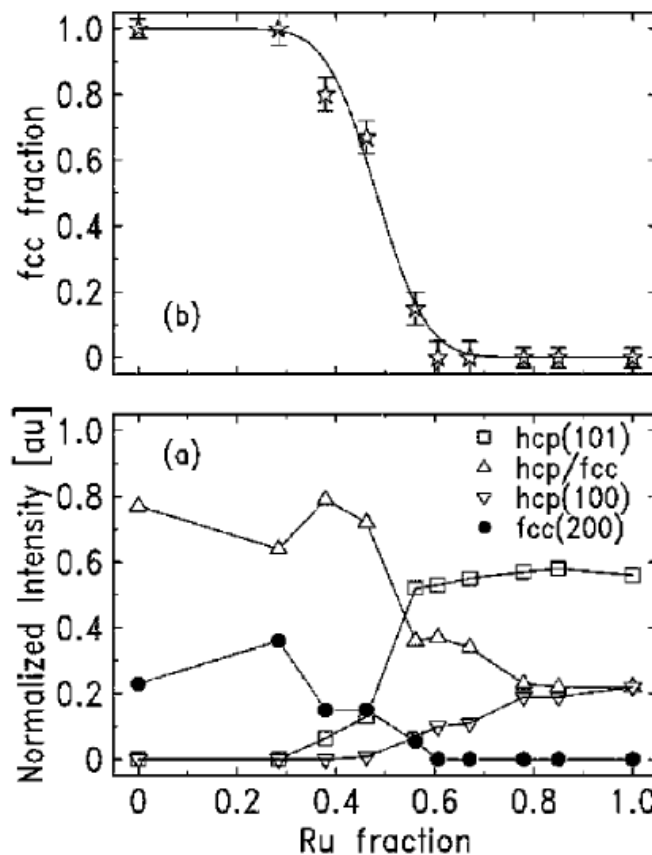
Grazing incidence diffraction

Structure and electrocatalysis of sputtered RuPt thin-film electrodes 130 Å thick

Grazing incidence x-ray diffraction



Phase diagram determination



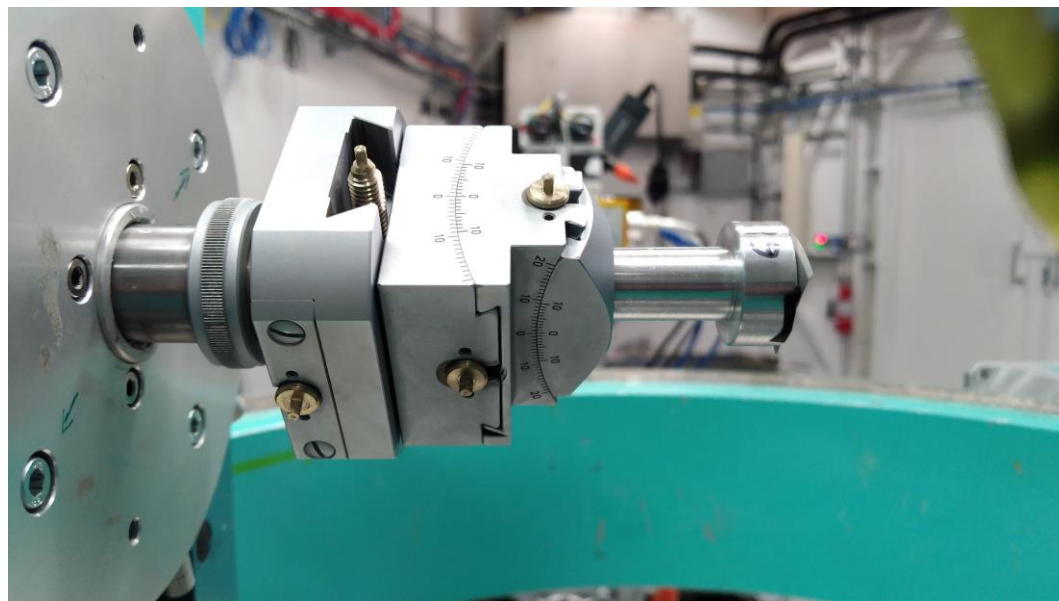
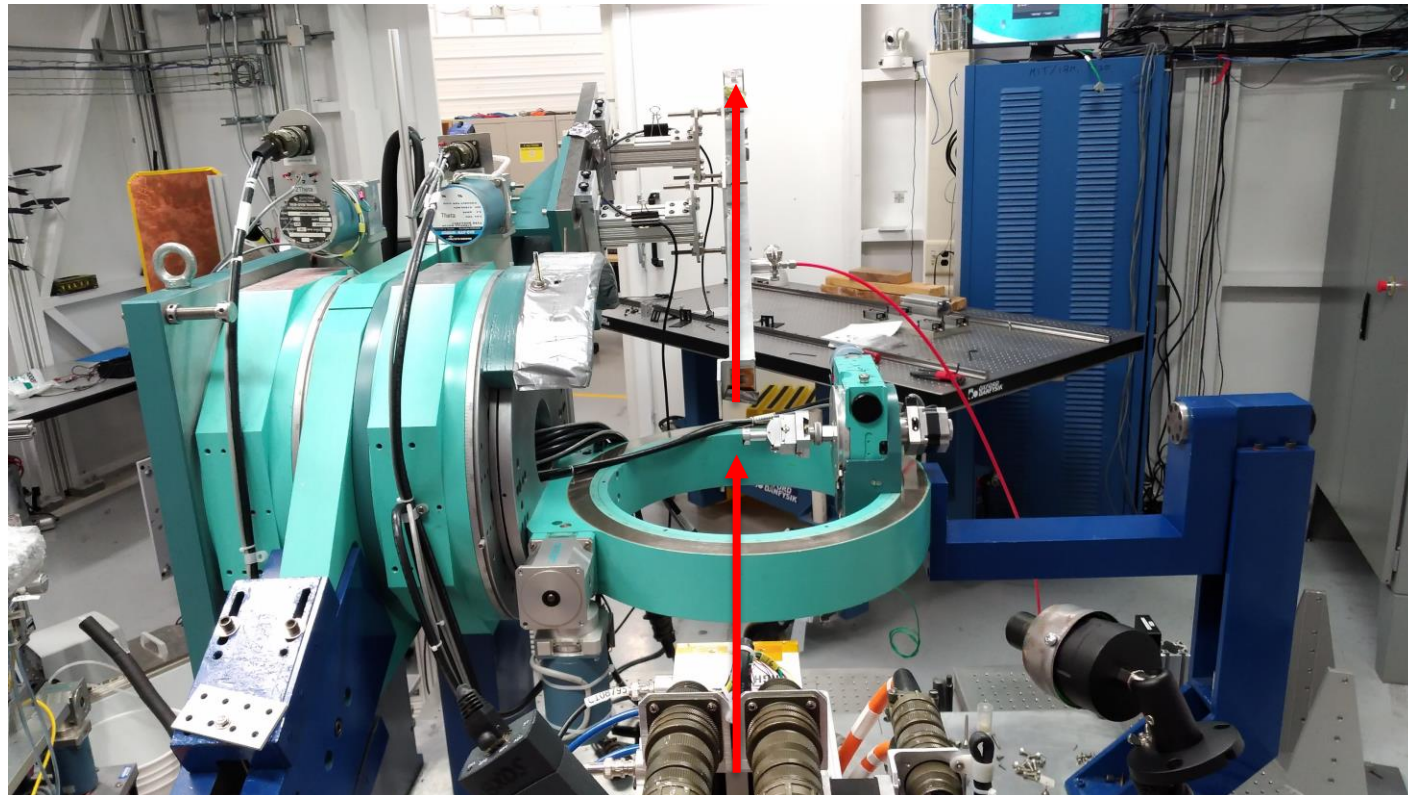
Grazing incidence diffraction

applied to

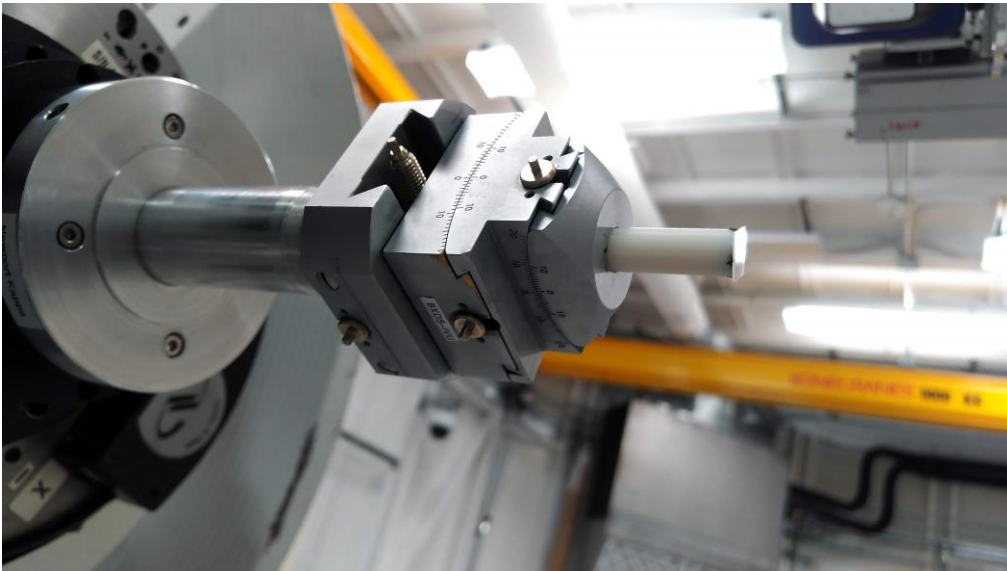
Single crystal films



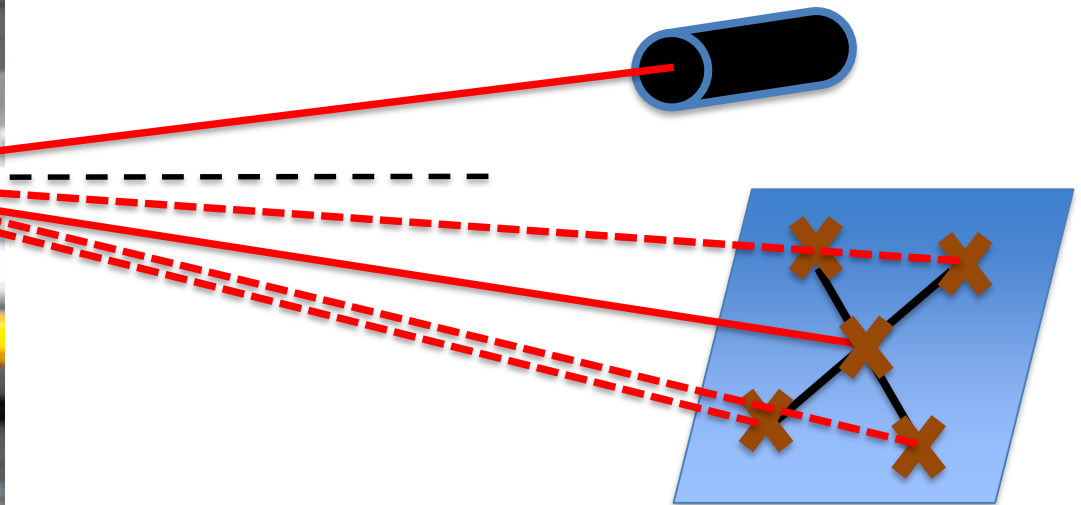
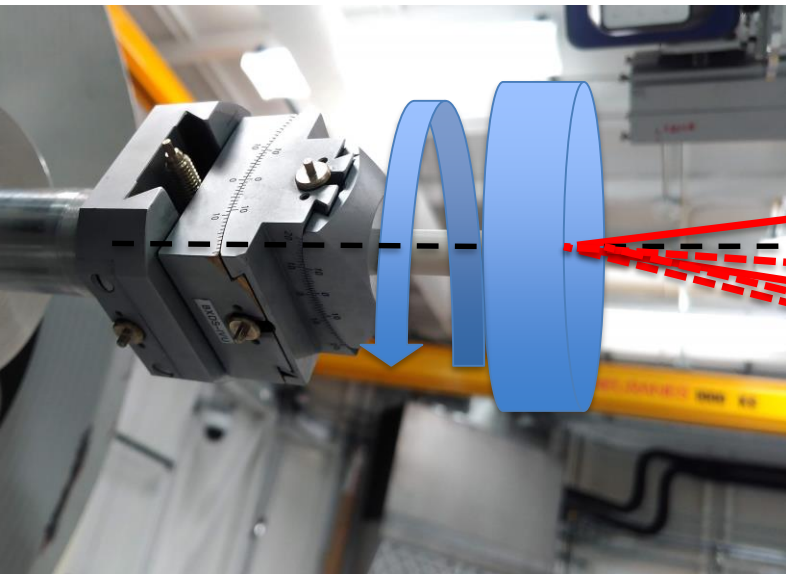
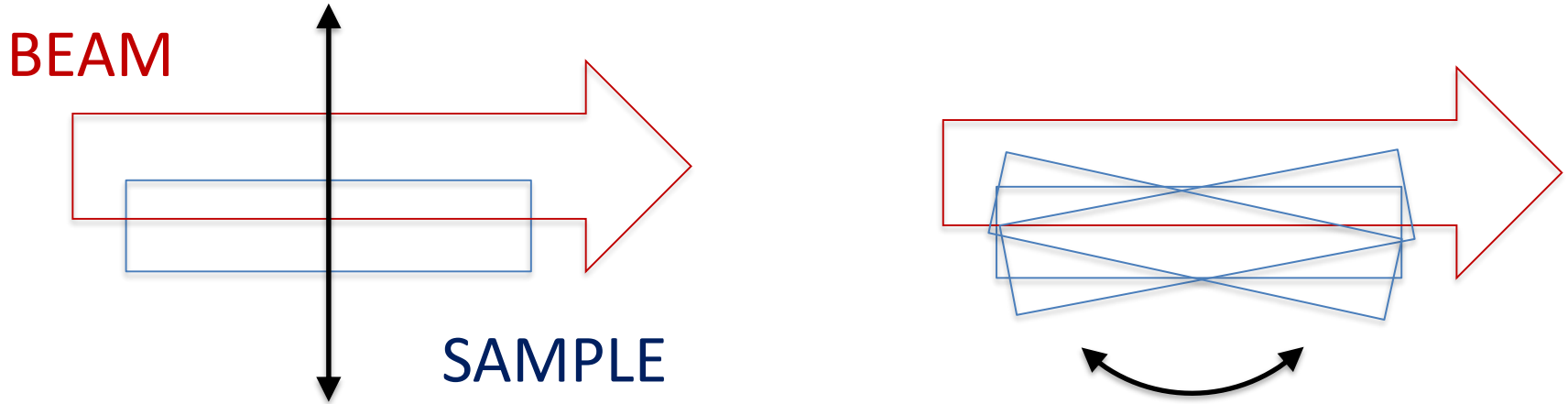
GID setup



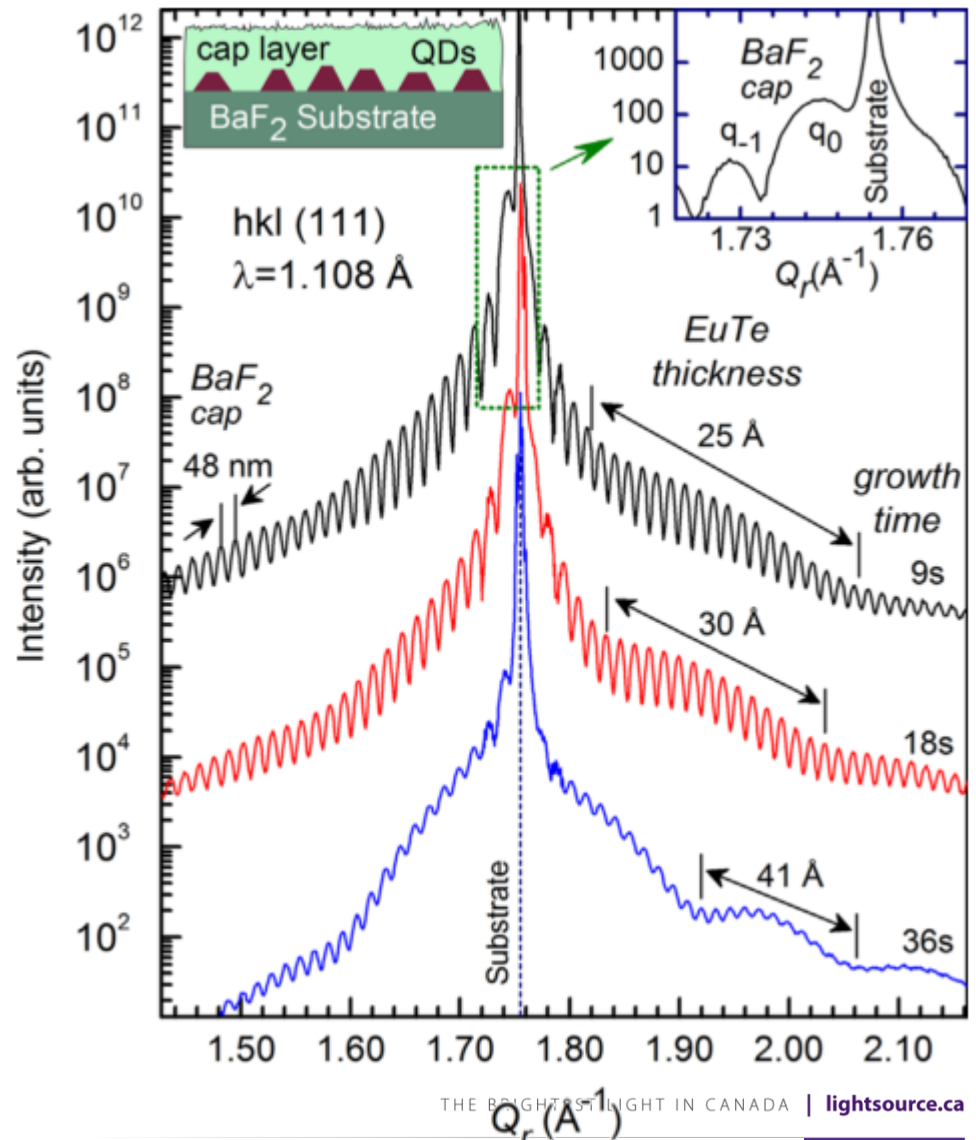
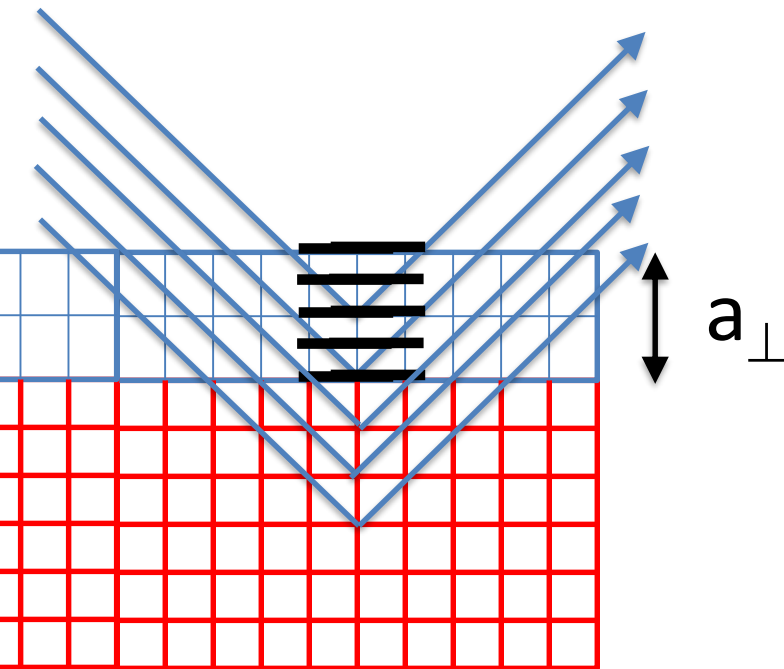
GID setup



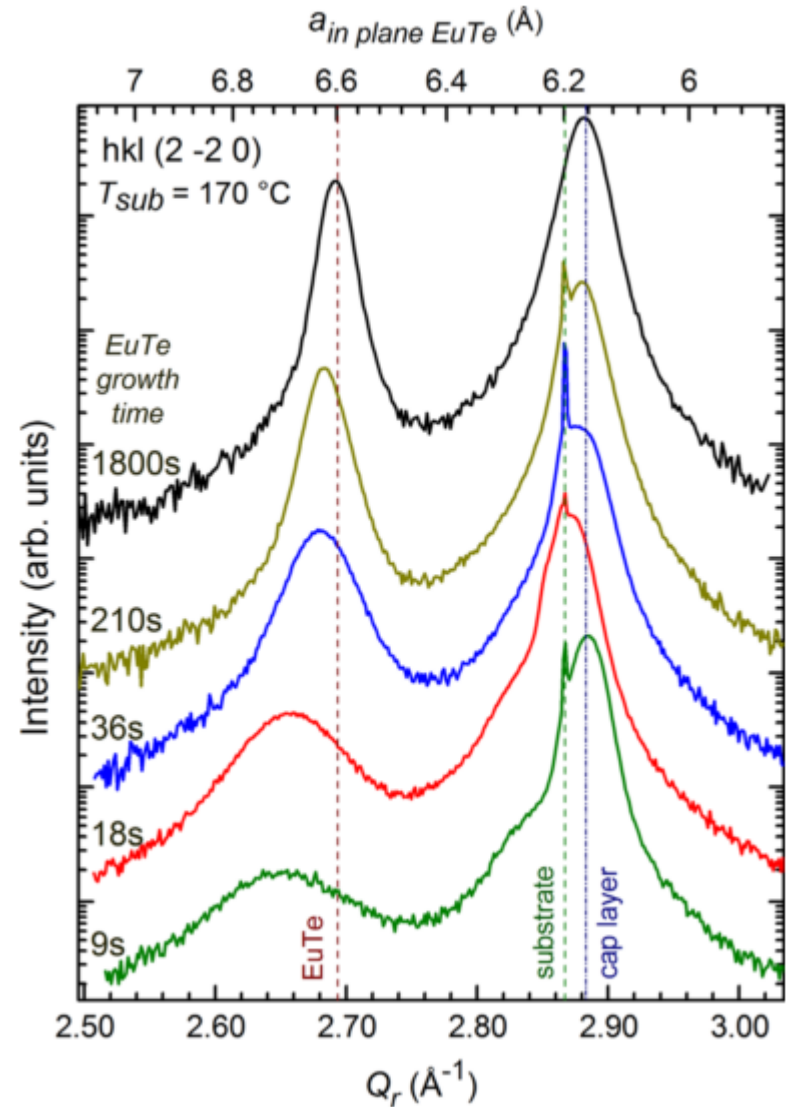
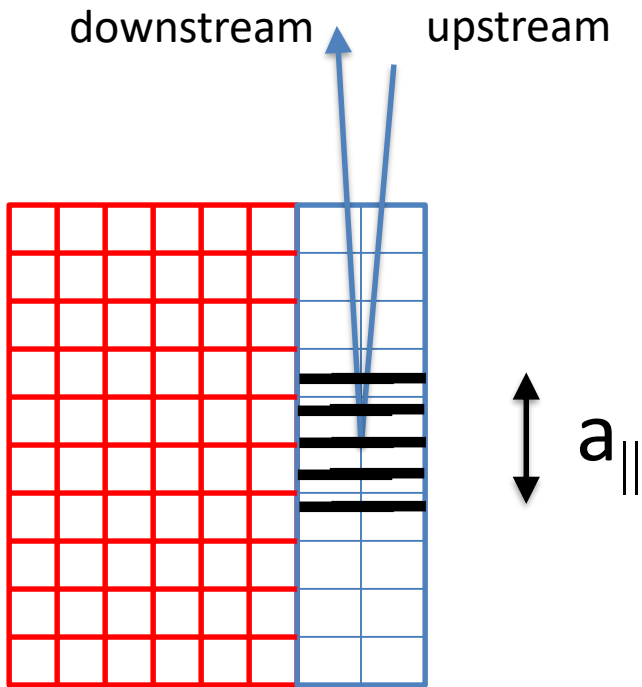
Sample alignment



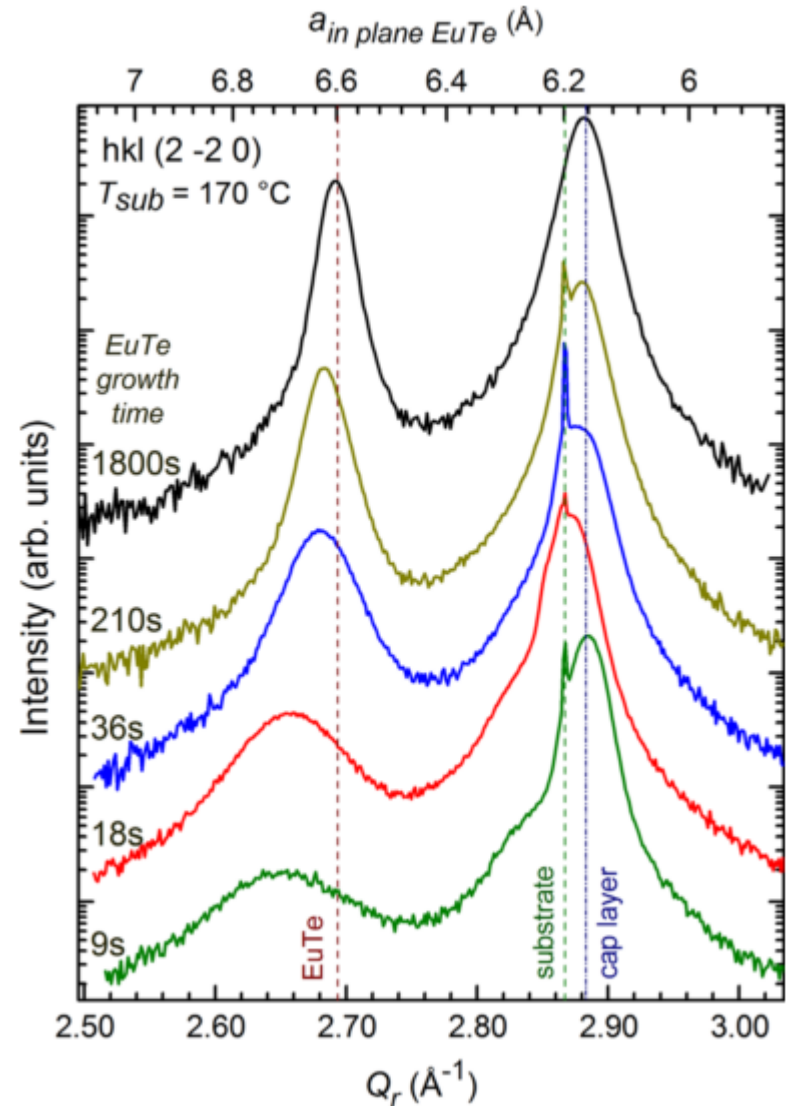
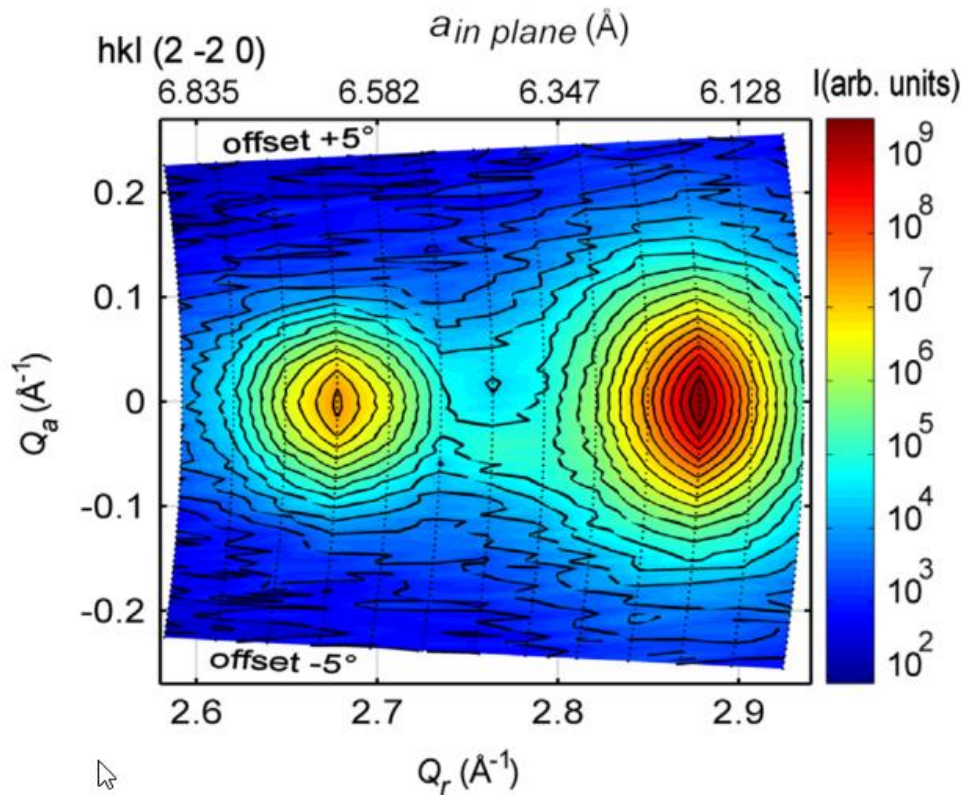
Not-Grazing incidence diffraction



Grazing incidence diffraction



Grazing incidence diffraction



Small angle x-ray reflectivity

Single crystal films

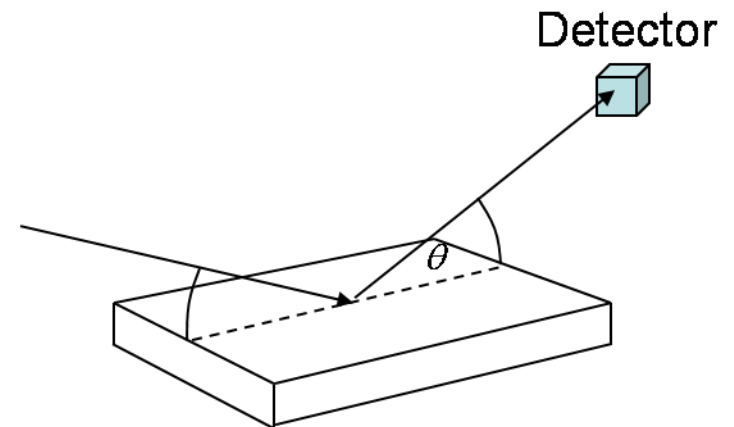
Polycrystalline films

Amorphous films



Small angle X-Ray reflectivity

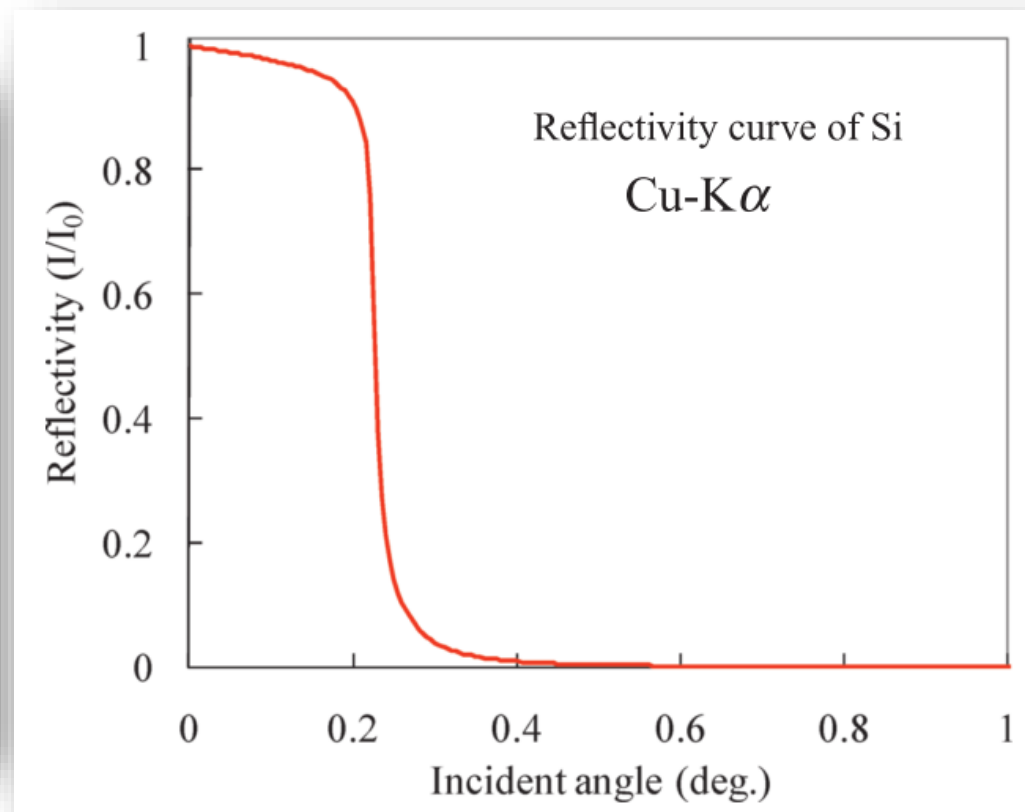
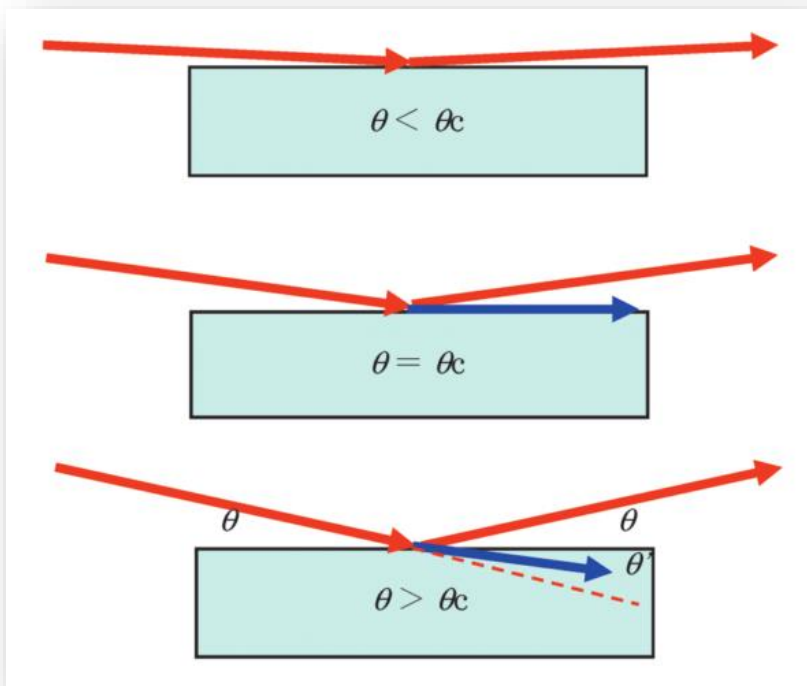
- Reflectivity yields information about the
 - Thicknesses
 - Density / porosity
 - Roughness of the interfaces
- Other names:
 - X-ray specular reflectivity
 - X-ray reflectometry
 - XRR



No diffraction!



Small angle X-Ray reflectivity



$$\theta_c \sim \lambda \sqrt{\rho}$$

The Rigaku Journal, **26(2)**, 2010

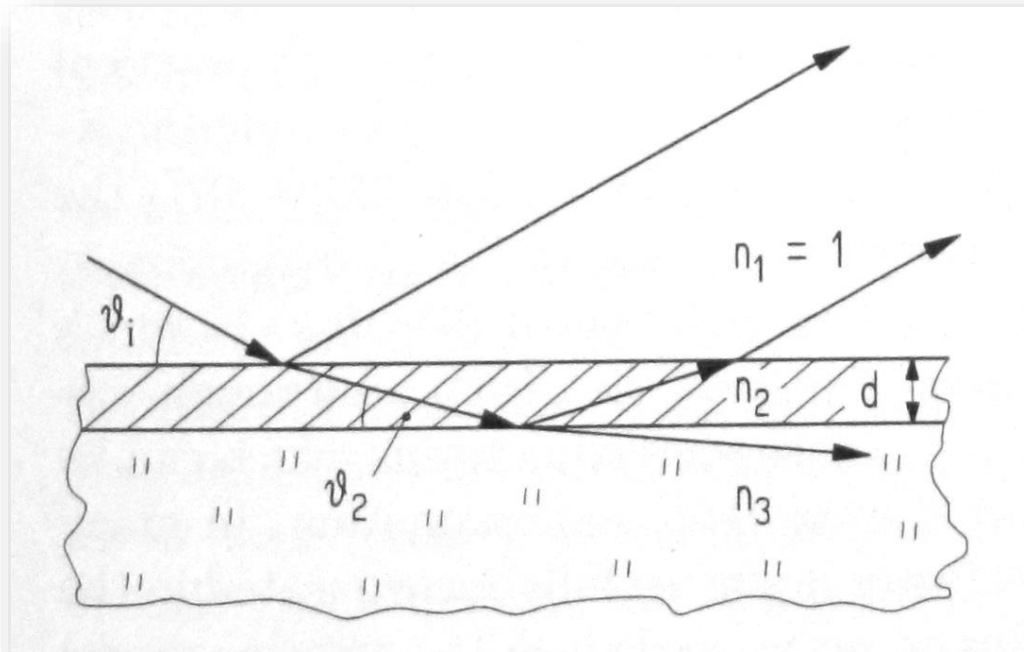


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Small angle X-Ray reflectivity



Snell's law

$$n_1 \cos \vartheta_1 = n_2 \cos \vartheta_2$$

$$n = 1 - \delta + i \beta$$

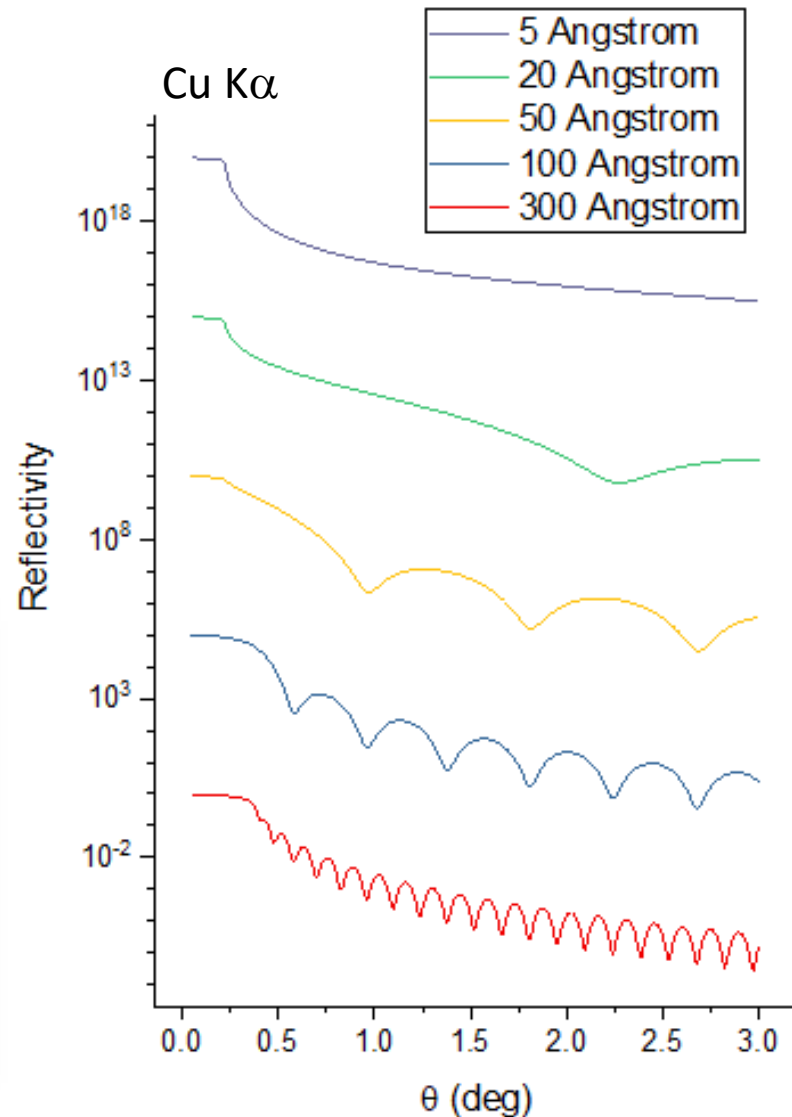
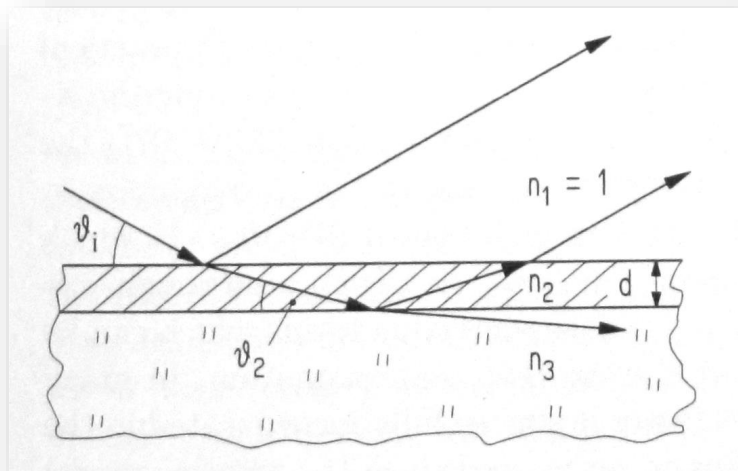


Small angle X-Ray reflectivity

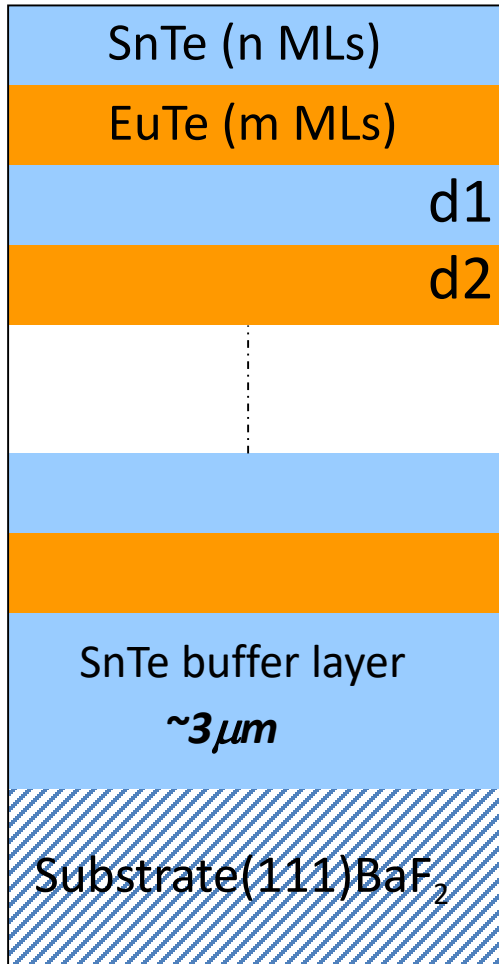
Reflectivity of a chromium film on top of silicon substrate, Cr/Si, for different thicknesses between 5 and 300 Å.

Kiessig fringes

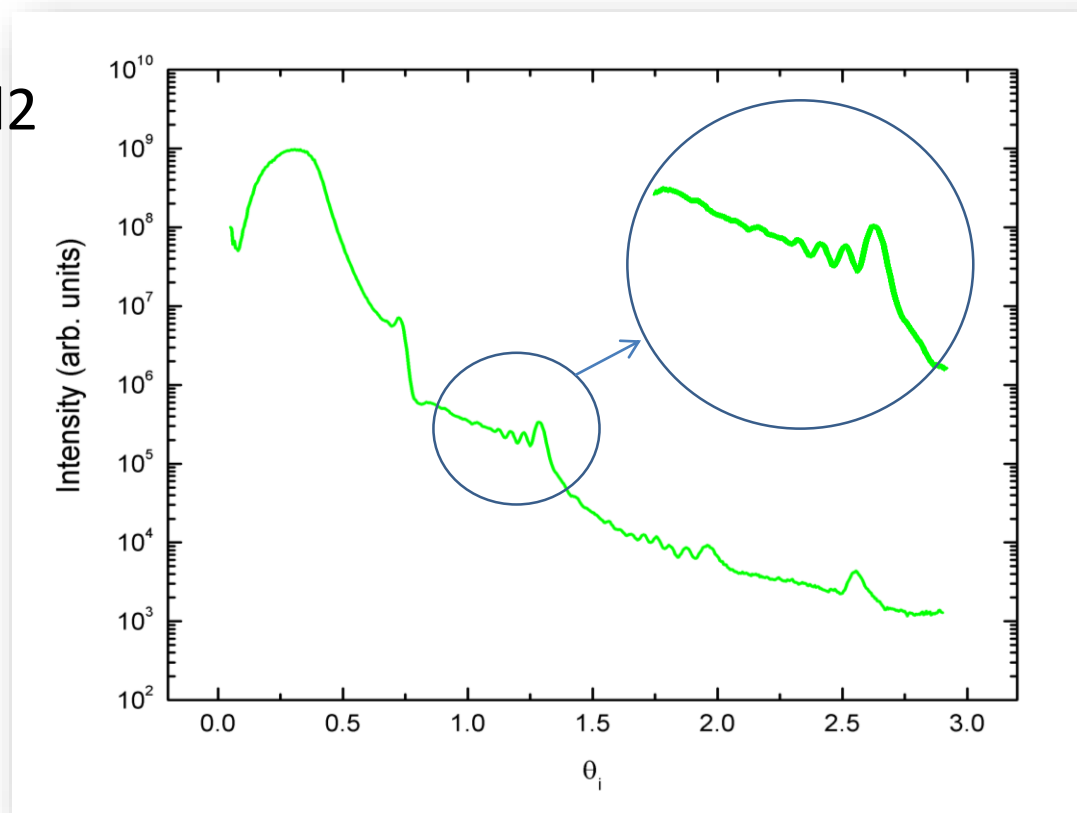
$$d = \frac{\lambda}{2\Delta\theta_r}$$



Small angle X-Ray reflectivity



$$D=d1+d2$$



$$d = \frac{\lambda}{2\Delta\vartheta_i}$$

Kiessig fringes spacing:

0.61 deg ~ 83 Å (SL period)

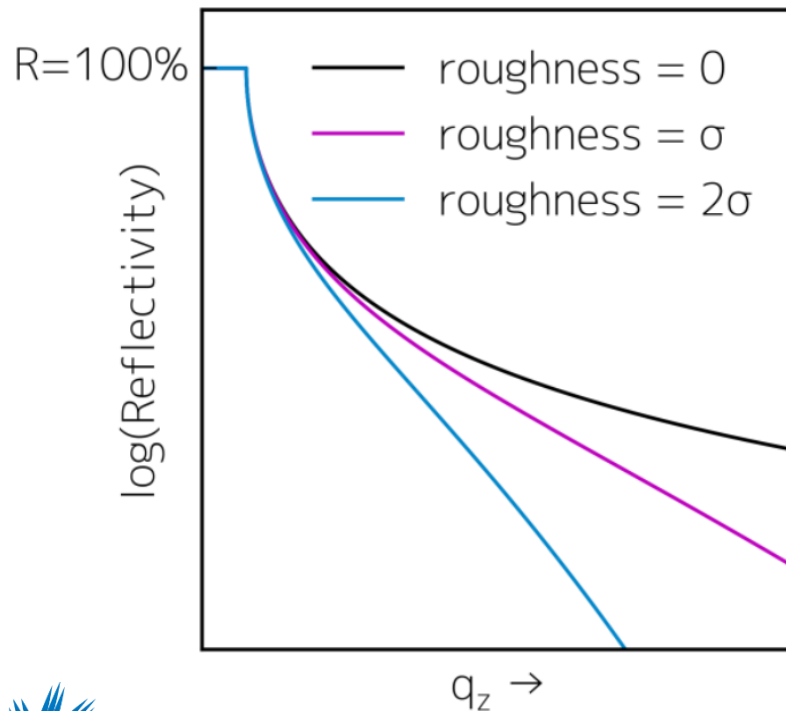
0.05 deg ~ 994.9 Å (Stack thickness)



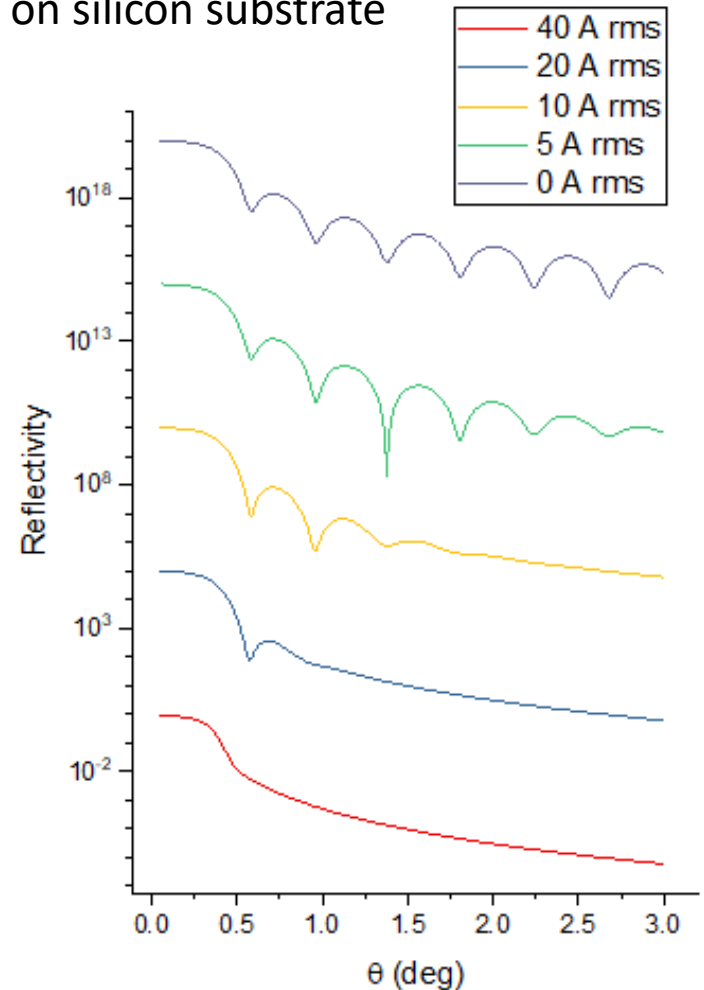
Small angle X-Ray reflectivity

Surface roughness

$$R_{rough} = R \cdot e^{-\frac{q_z^2 \sigma^2}{2}}$$



100 Angstrom chromium layer
on silicon substrate



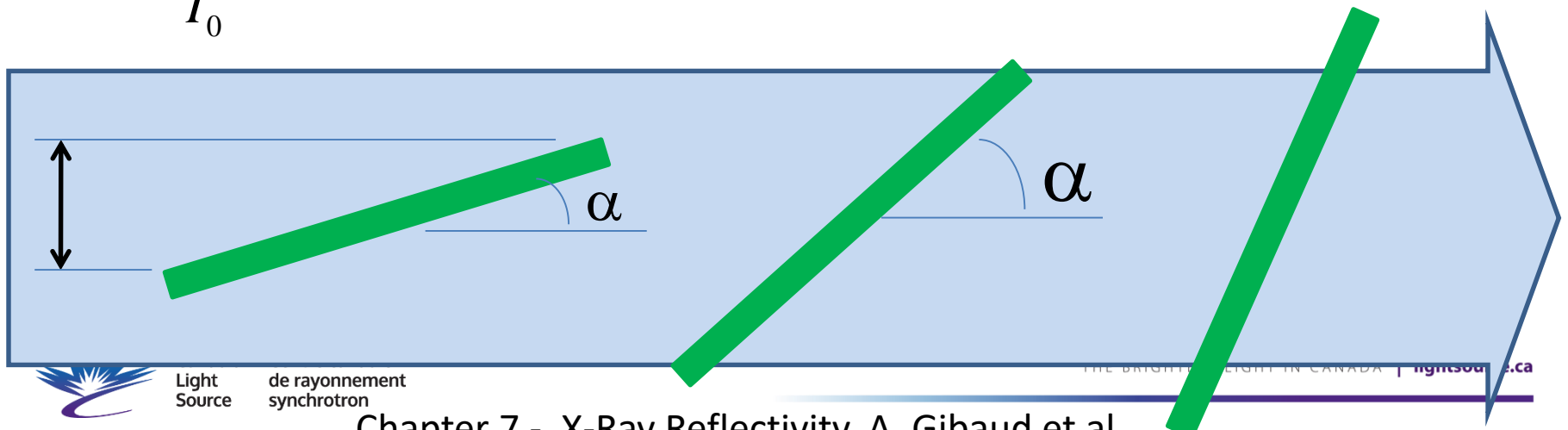
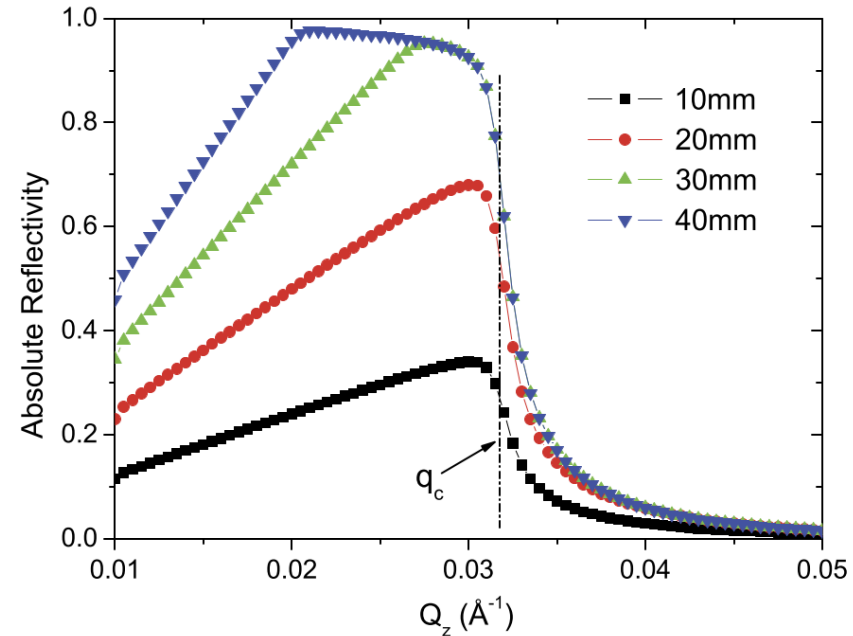
Small angle X-Ray reflectivity

Footprint correction

Beam footprint length:

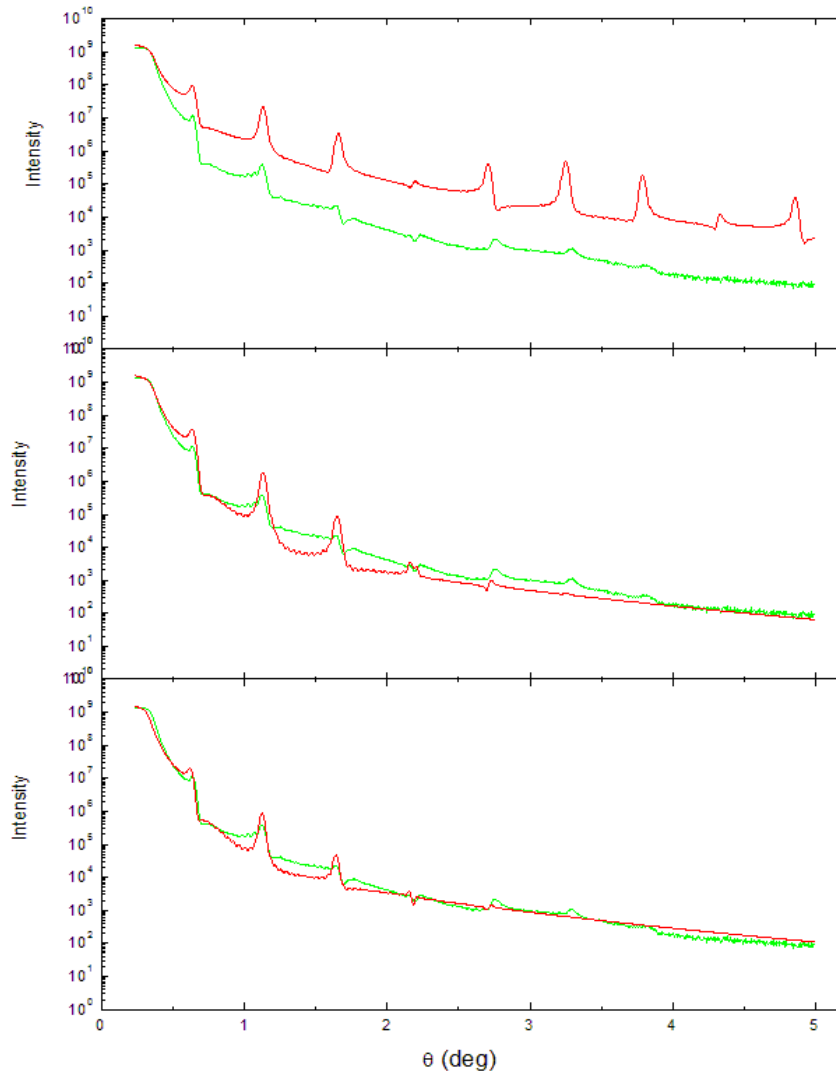
$$F = \frac{t}{\sin(\alpha)}$$

$$R = \frac{I}{I_0}$$



Small angle X-Ray reflectivity

Fits to the measurement



← Smooth interfaces

← Rough interfaces

← Lower densities
(porous sample?)

Oxide layer cap!
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Programs for simulating and fitting reflectivity

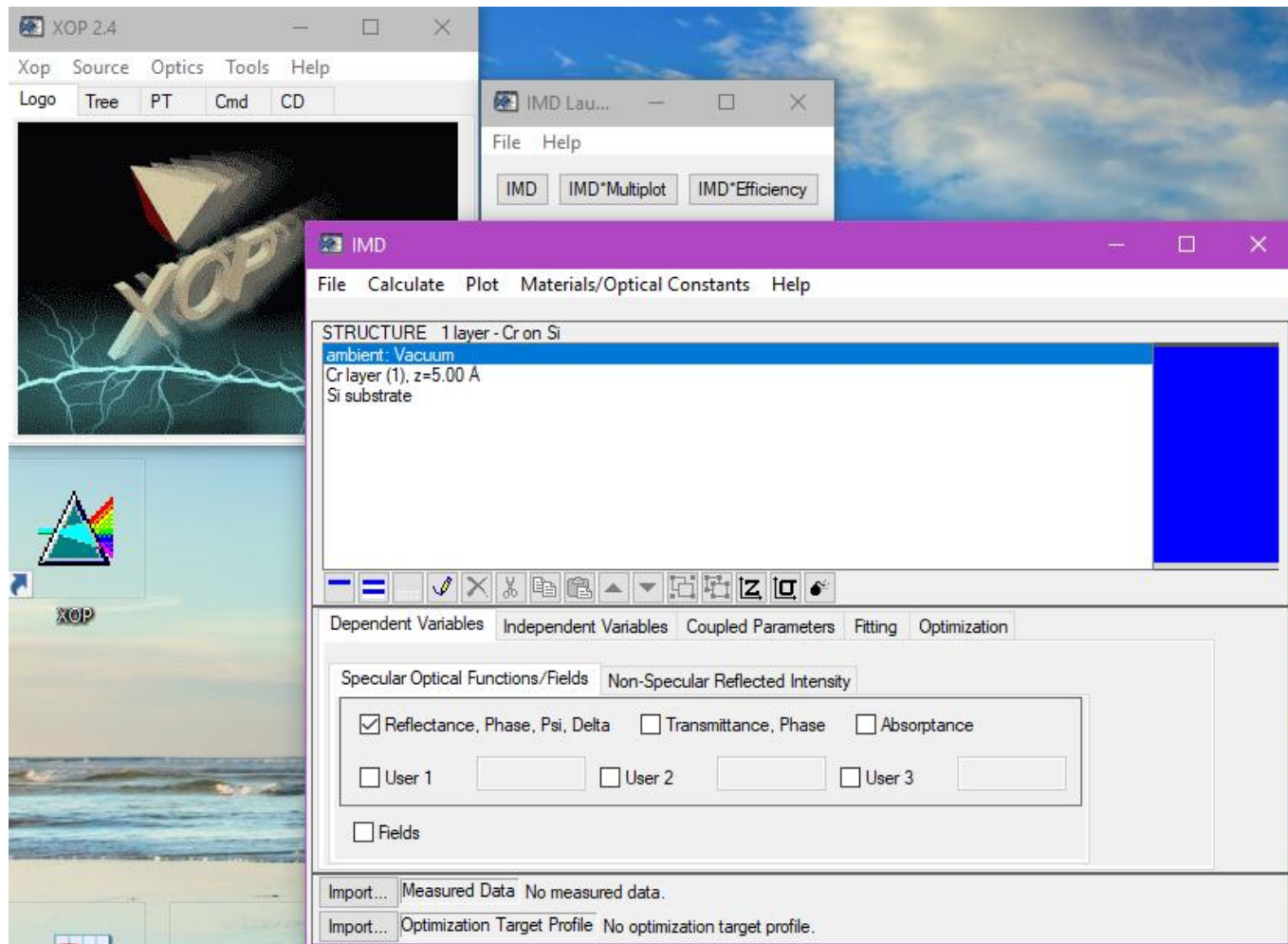
- GSAS II !
- Parratt 32
- RFit2000
- WinGixa (Panalytical)
- XOP / IMD

For more x-ray related softwares consult website:

<http://gisaxs.com/index.php/Software#Crystallography>



IMD/XOP to simulate x-ray reflectivity



<https://www.aps.anl.gov/Science/Scientific-Software/XOP>



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de rayonnement
synchrotron

<http://www.rxollc.com/idl/IMD.pdf>

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IMD/XOP to simulate x-ray reflectivity

The screenshot displays the XOP 2.4 software interface. The main window, titled "IMD", shows a structure definition for a single layer of Chromium (Cr) on a Silicon (Si) substrate. The structure is defined as follows:

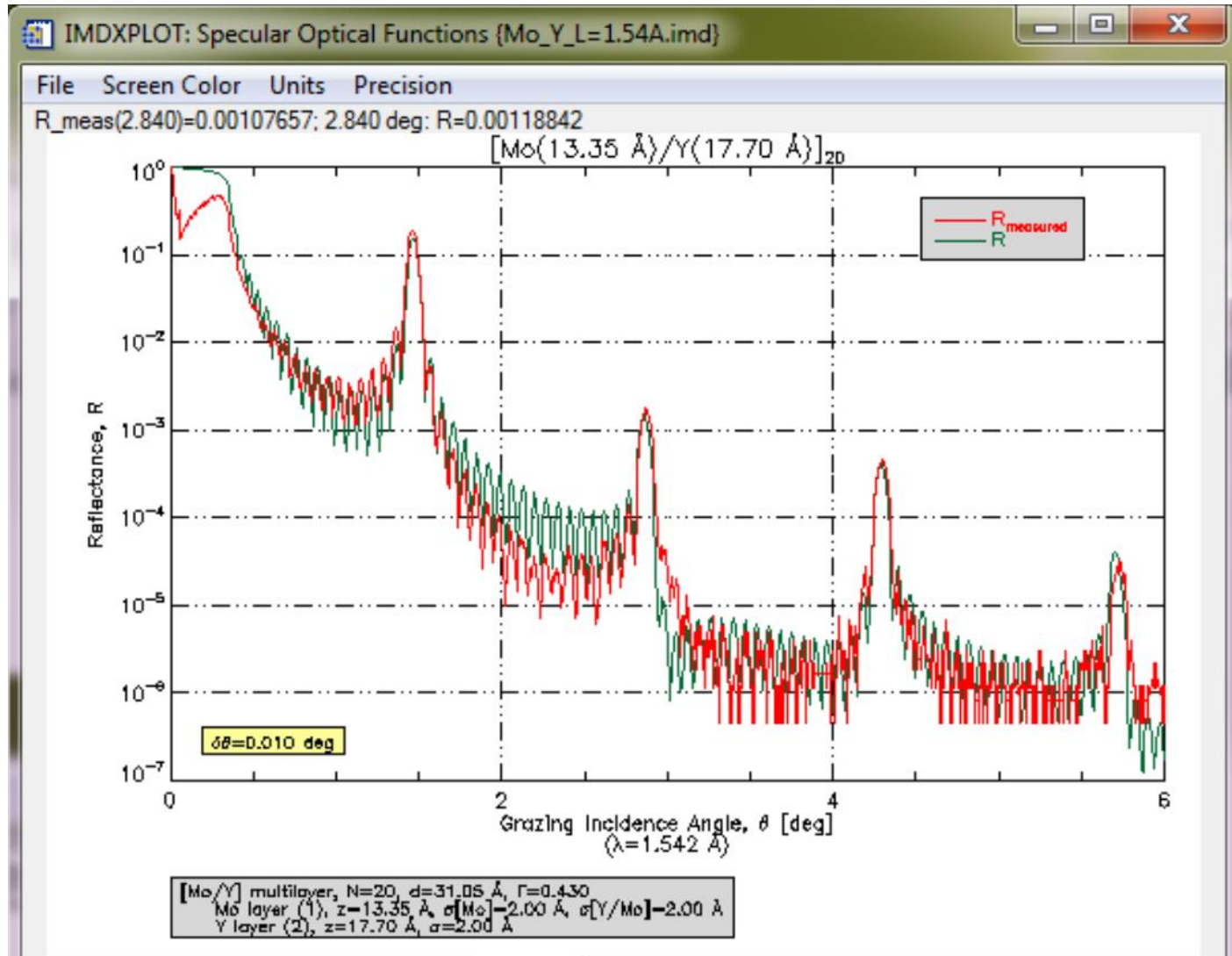
```
STRUCTURE 1 layer - Cr on Si  
ambient: Vacuum  
Cr layer (1), z=5.00 Å  
Si substrate
```

The "Dependent Variables" section lists the following parameters:

- Grazing Incidence Angle, Theta [1000 values: 0.050-3.000 deg]
- Wavelength, Lambda [1.540 Å]

The interface also includes a menu bar (File, Calculate, Plot, Materials/Optical Constants, Help), a toolbar with various icons, and a status bar at the bottom with options like "Import... Measured Data" and "Import... Optimization Target Profile".

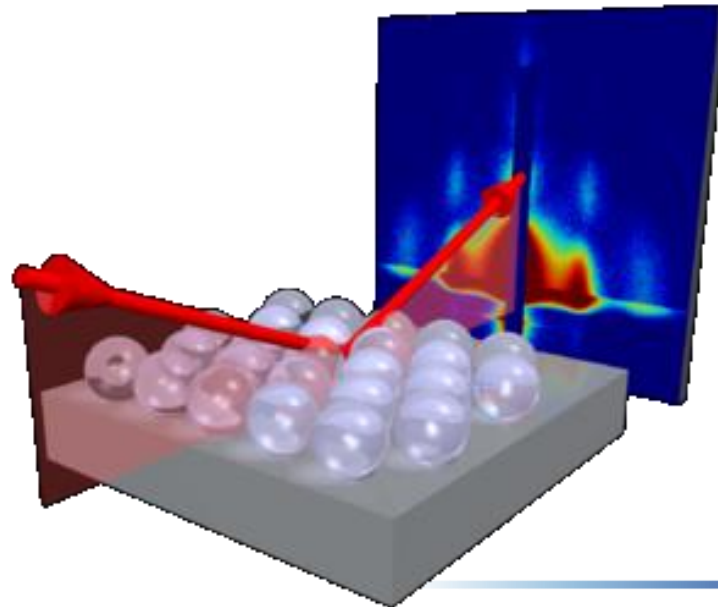
IMD/XOP to simulate x-ray reflectivity



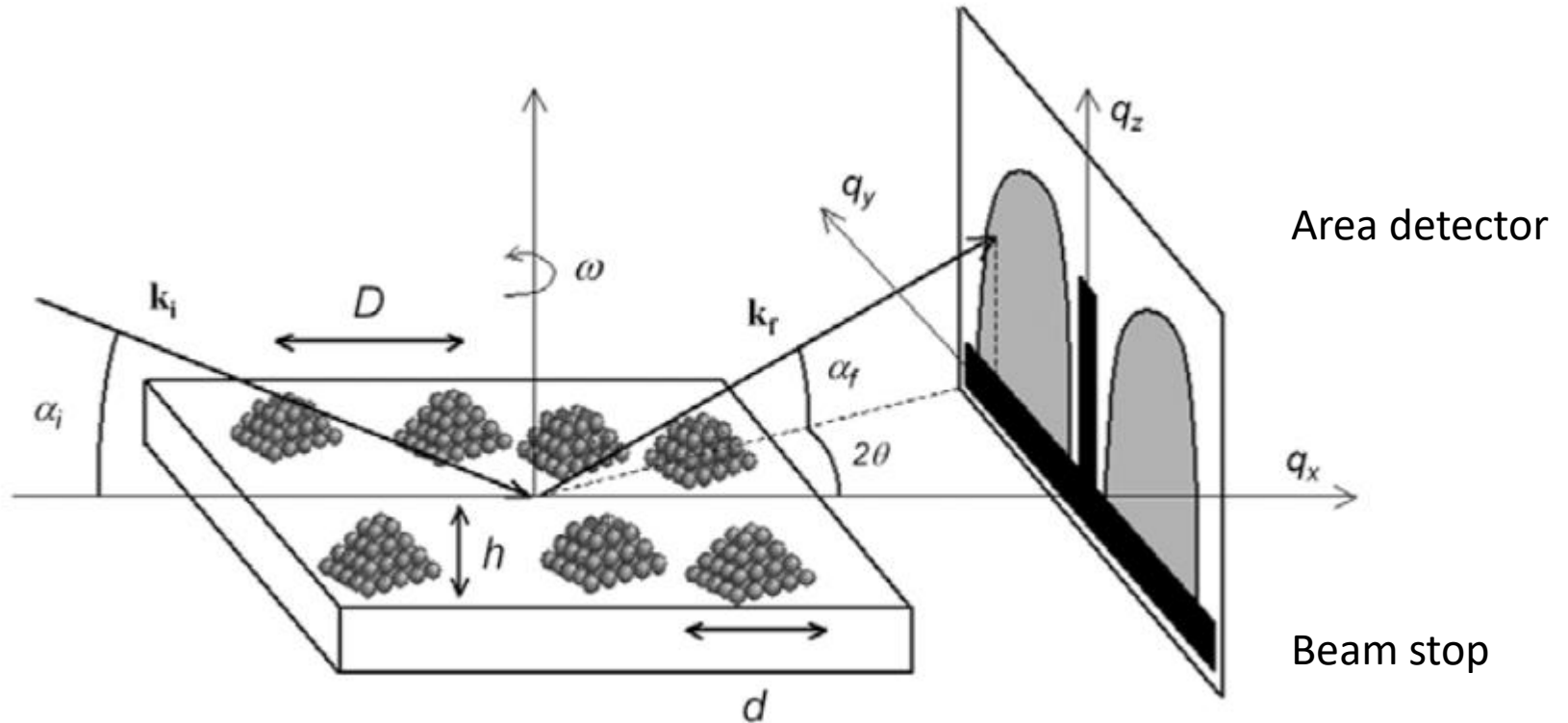
Grazing incidence

Small angle X-ray scattering

GISAXS



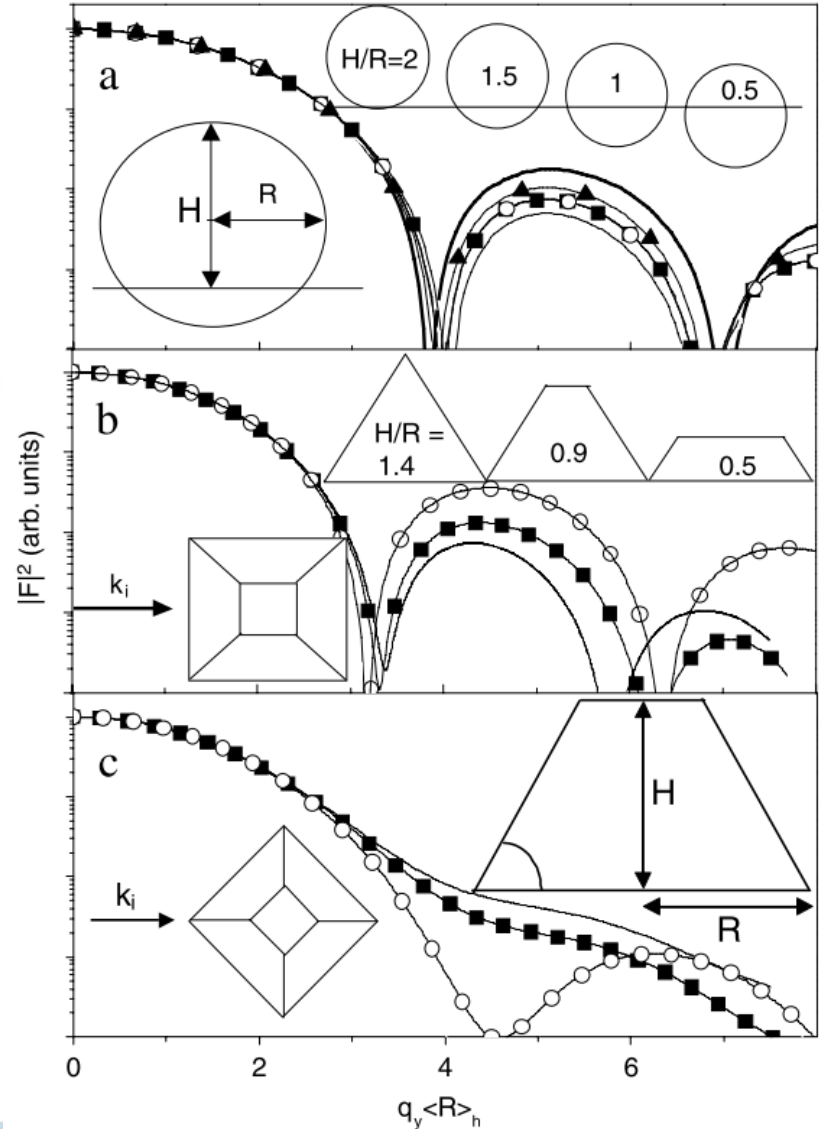
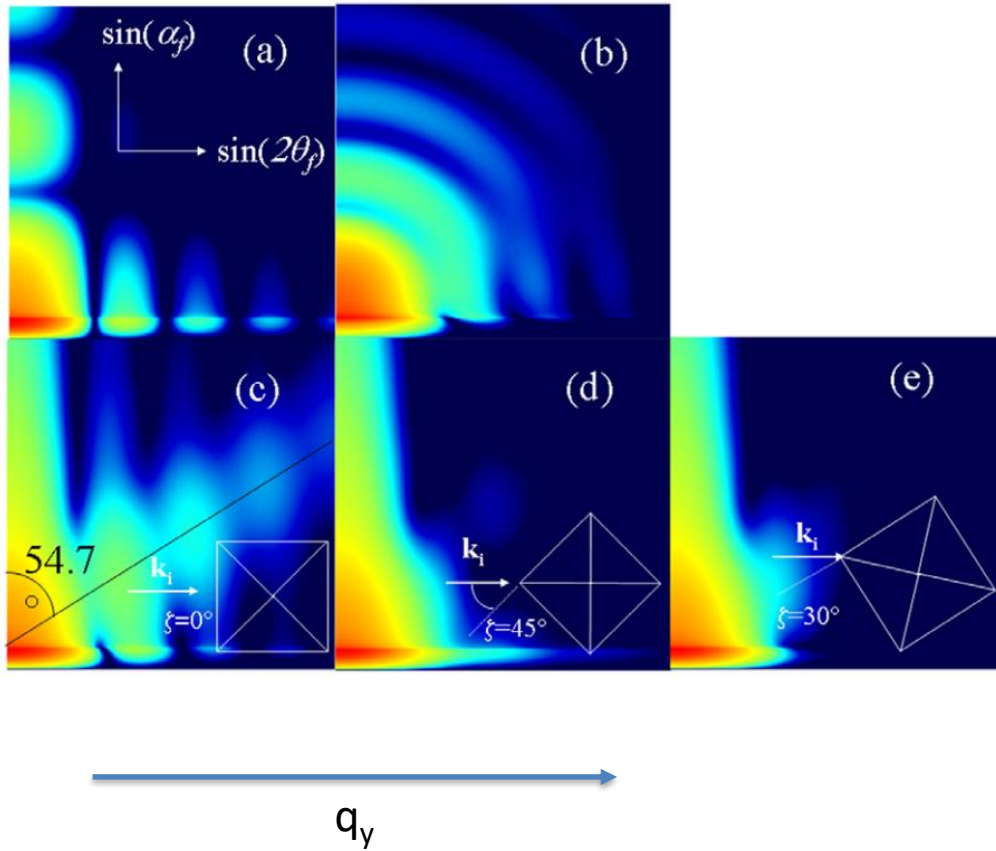
GISAXS measurements



Surface Science Reports **64**(8): 255-380, 2009.



GISAXS



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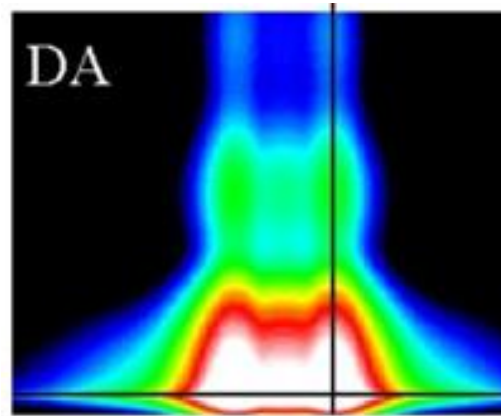
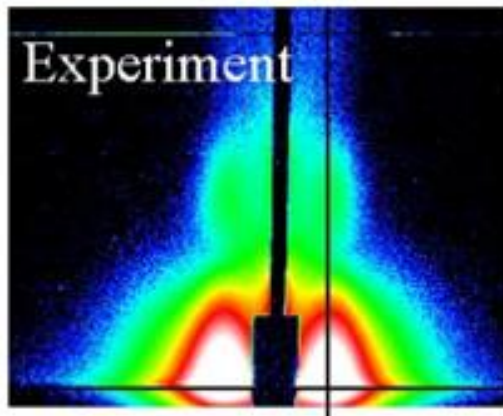
Modelling software

- R. Lazzari, IsGISAXS: A program for grazing-incidence small-angle X-ray scattering analysis of supported islands, J. Appl. Crystallogr. 35 (2002) 406–421.
- <http://www.insp.jussieu.fr/oxydes/IsGISAXS/isgisaxs.htm>
- Jiang, Z. (2015). "GIXSGUI: a MATLAB toolbox for grazing-incidence X-ray scattering data visualization and reduction, and indexing of buried three-dimensional periodic nanostructured films." Journal of Applied Crystallography **48**(3): 917-926.
- <https://www.aps.anl.gov/Science/Scientific-Software/GIXSGUI>
- FitGISAXS, BornAgain, HipGISAXS, NANOCELL, SimDiffraction,...

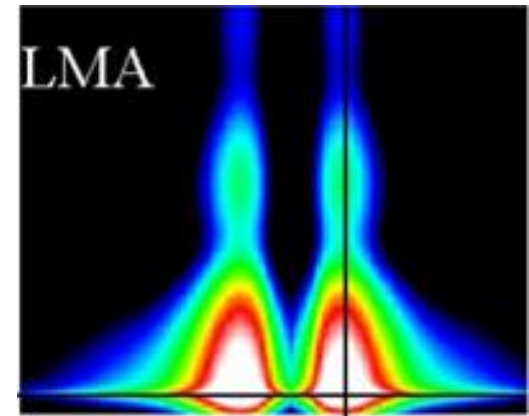


IsGISAXS

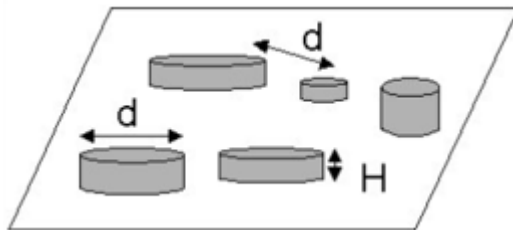
Pd islands on MgO(100)



Decoupling Approximation (DA)



Local Monodisperse Approximation (LMA)



PARAMETERS :

cylinder

$D = 20.7 \text{ nm}$

$d = 10.2 \text{ nm}$

$H = 6.6 \text{ nm}$

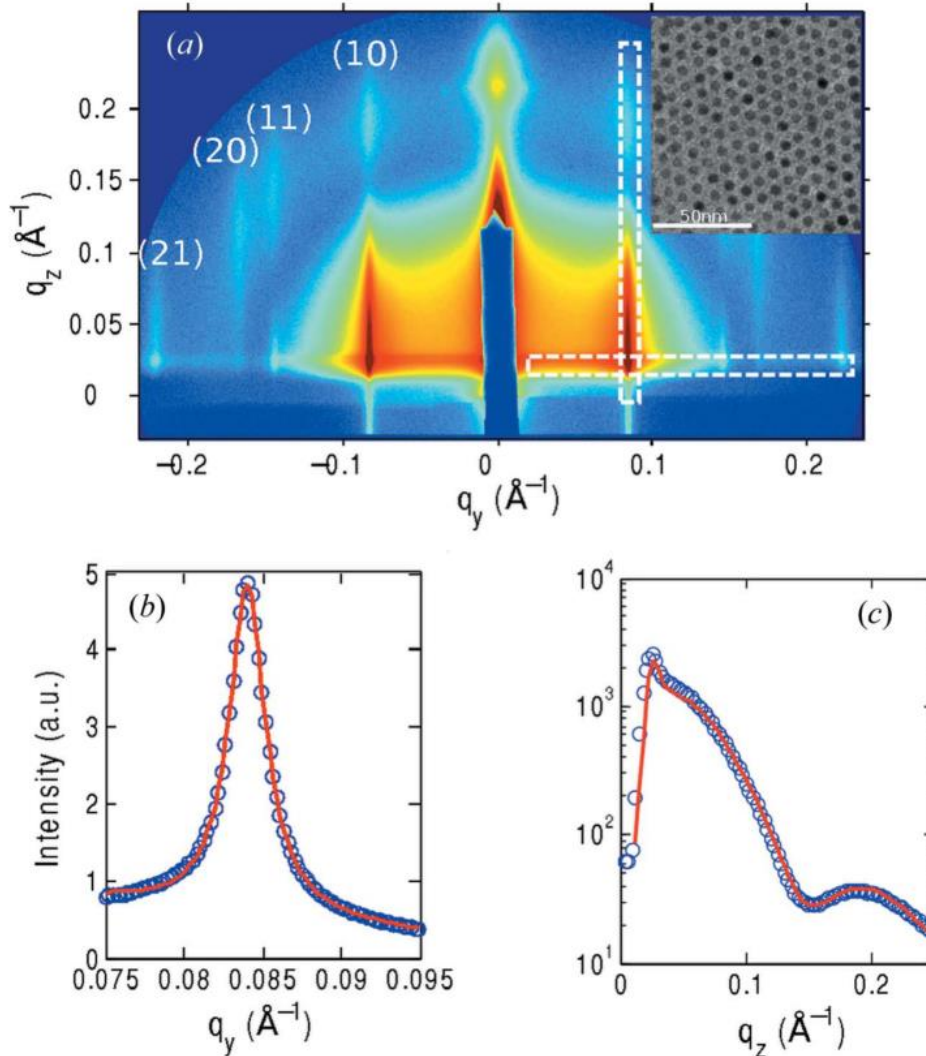
$\sigma_R = 1.3$

$\sigma_H = 1.1$



GISAXS

Spherical gold nanoparticles in silicon



In Situ GISAXS

Gold film growth on conducting polymer

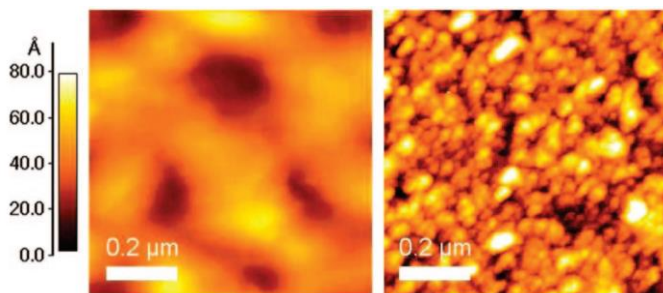
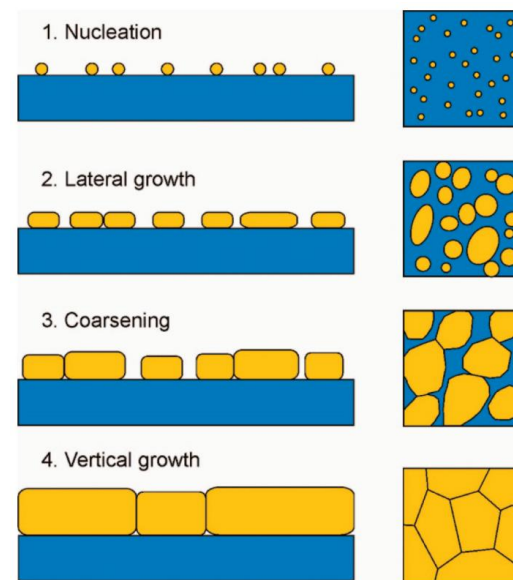
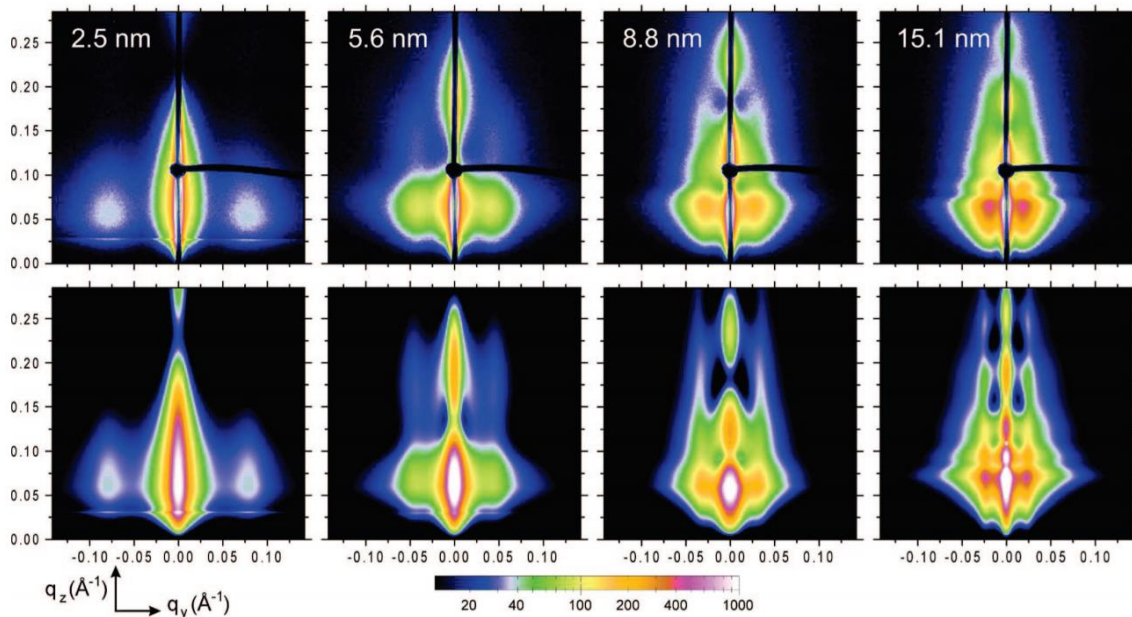


Table 1. Morphological Parameters Extracted from Simulation of the Data by Use of a Model Consisting of Parallelepiped and Spheroid Particle Geometries To Describe the Cluster Shape^a

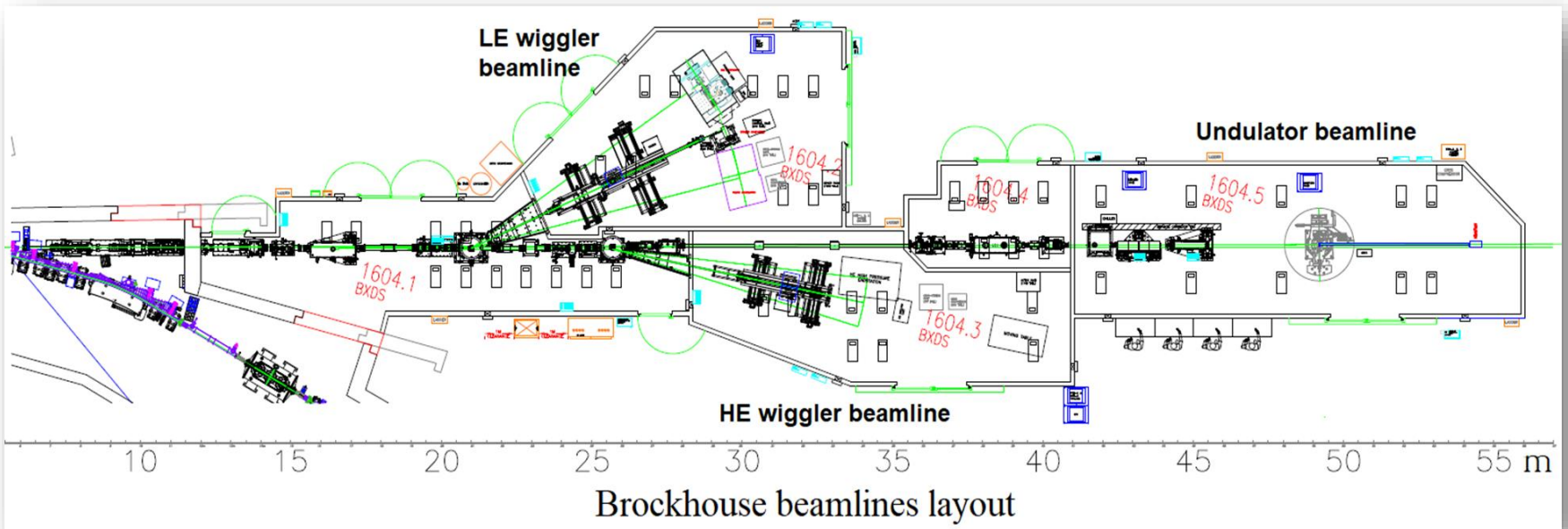
t (min)	d_0 (nm)	d (nm)	r_p (nm)	σ_p (nm)	h_p (nm)	r_s (nm)	σ_s (nm)	h_s (nm)	D (nm)	ω (nm)
9	3.9	2.5	4.8	20.0	3.6	4.8	11.0	4.3	11.8	3.8
19	8.2	5.6	9.1	22.5	6.1	9.1	5.3	6.8	19.0	7.2
29	12.5	8.8	13.5	17.6	8.8	13.5	14.9	9.9	27.0	10.2
49	21.1	15.1	20.0	36.0	15.2	20.0	18.0	16.4	40.0	15.2



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Thin film characterization at the Brockhouse sector



Beamlines energy range

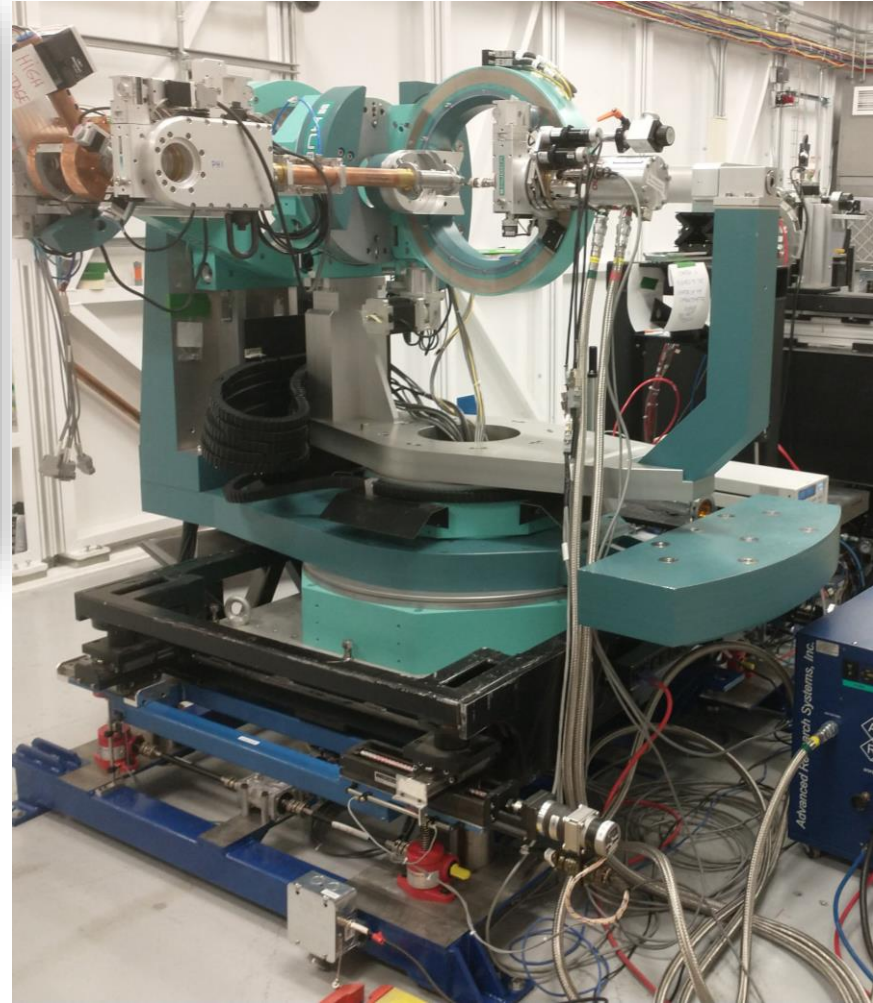
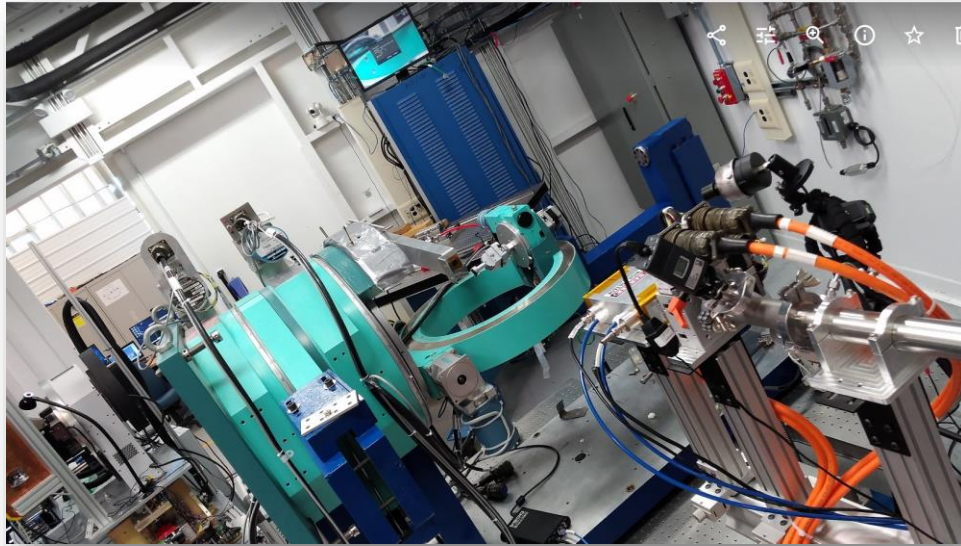
Lower energy wiggler beamline: 7 – 22 keV

Undulator beamline: 5 – 24 keV

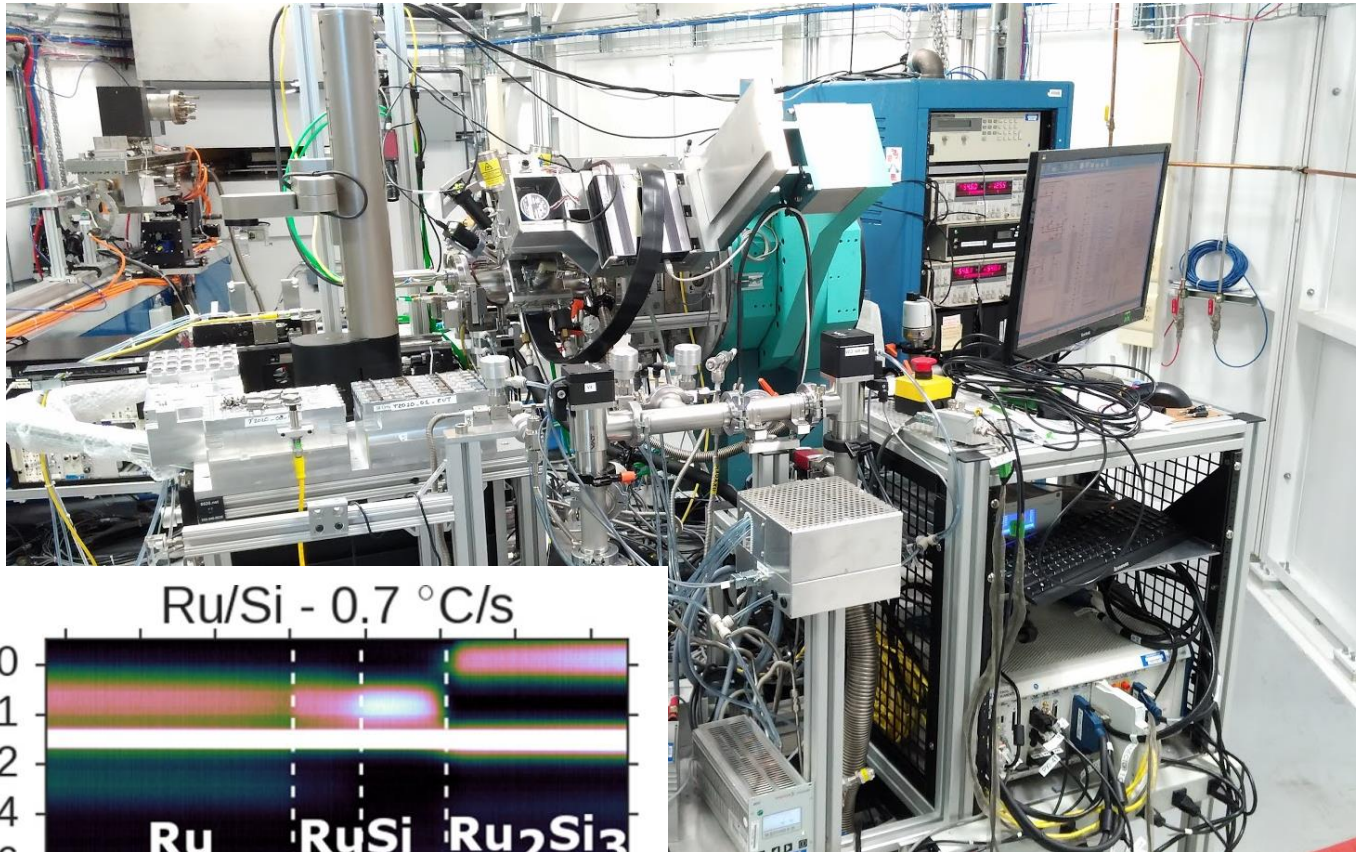
Higher Energy wiggler beamline: 20 – 95 keV



Thin film characterization at the Brockhouse sector



Thin film characterization at the Brockhouse sector



IBM in-situ station

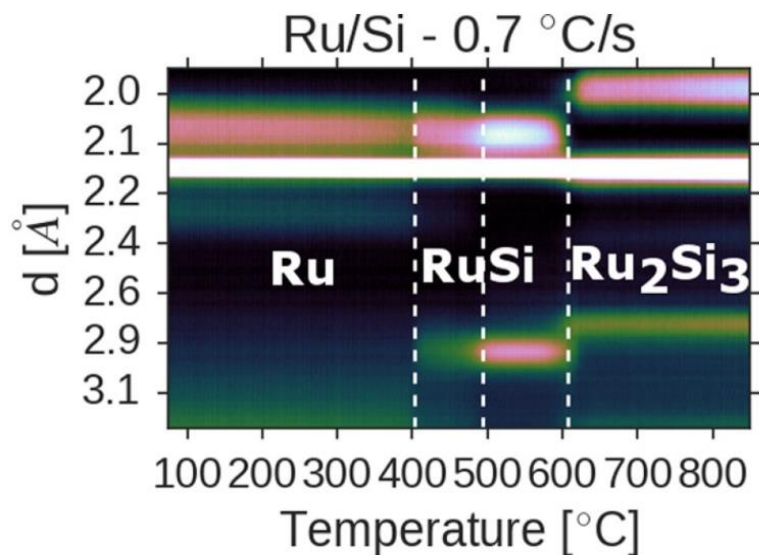
XRD

RTA up to 1000 °C

H₂ or N₂ ultrahigh purity atmosphere

Resistance probe

Roughness probe



BXDS – Brockhouse X-ray Diffraction and Scattering for materials science

brockhouse.lightsource.ca



**Brockhouse Diffraction
Sector Beamlines**

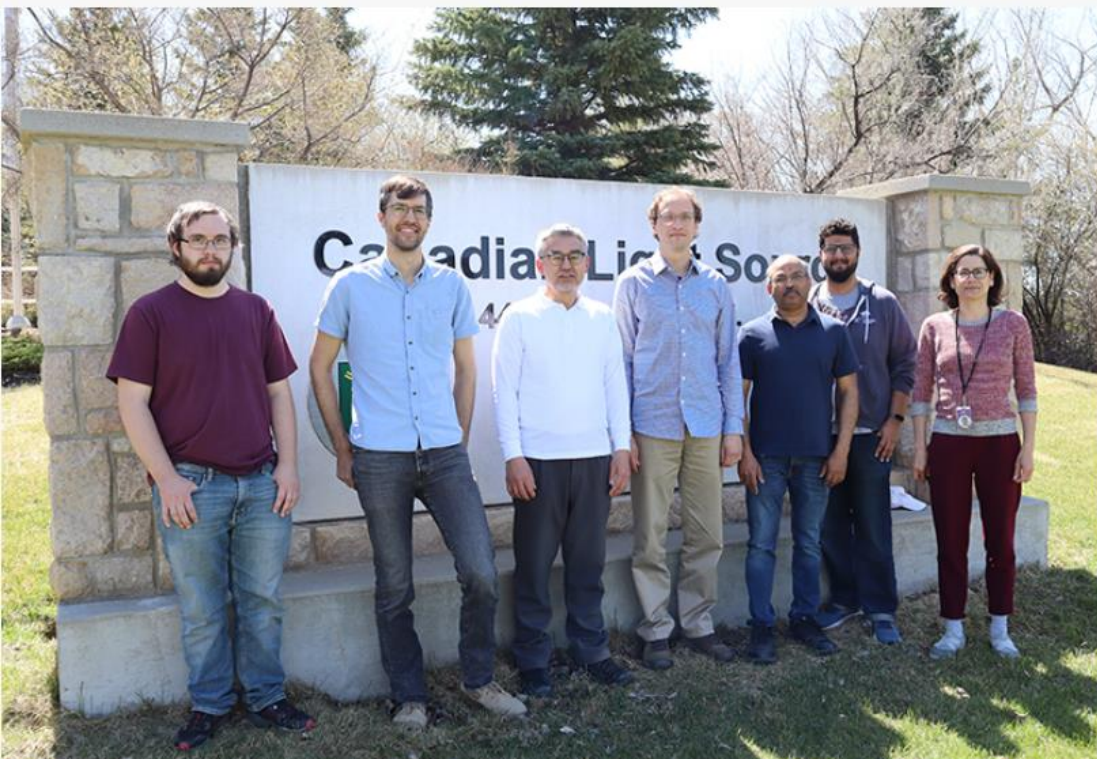
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High resolution powder diffraction

Pair distribution function (PDF)

High energy diffraction for in-situ studies

Reciprocal space mapping

Small/wide angle X-ray scattering (SAXS/WAXS)

High pressure crystallography

X-ray reflectivity

Grazing incidence diffraction (GID)

Anomalous diffraction and magnetic diffraction



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Conclusions

If you have a sample... → measure XRD!

If it is a very thin film... → try one of the techniques with grazing incidence geometry

They yield information about:

- ✓ Structure / texture / stress
- ✓ Defects
- ✓ Thickness
- ✓ Roughness
- ✓ Composition, interdiffusion, gradients
- ✓ Size, morphology, ordering
- ✓ How does it perform under real working conditions?
→ Come to a synchrotron and perform in-situ experiments!



Further reading

- Thin Film Analysis by X-Ray Scattering, by Mario Birkholz, 2006
- Surface Science Techniques
 - Chapter 6: Grazing incidence X-Ray diffraction by Osami Sakata and Masashi Nakamura
 - Chapter 7: X-Ray Reflectivity by Gibaud, Chebil and Beuvier
- Renaud, G., et al. (2009). "Probing surface and interface morphology with Grazing Incidence Small Angle X-Ray Scattering." Surface Science Reports **64(8)**: 255-380



Acknowledgments



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